

Photodetectors

Lecture at EDIT 2018

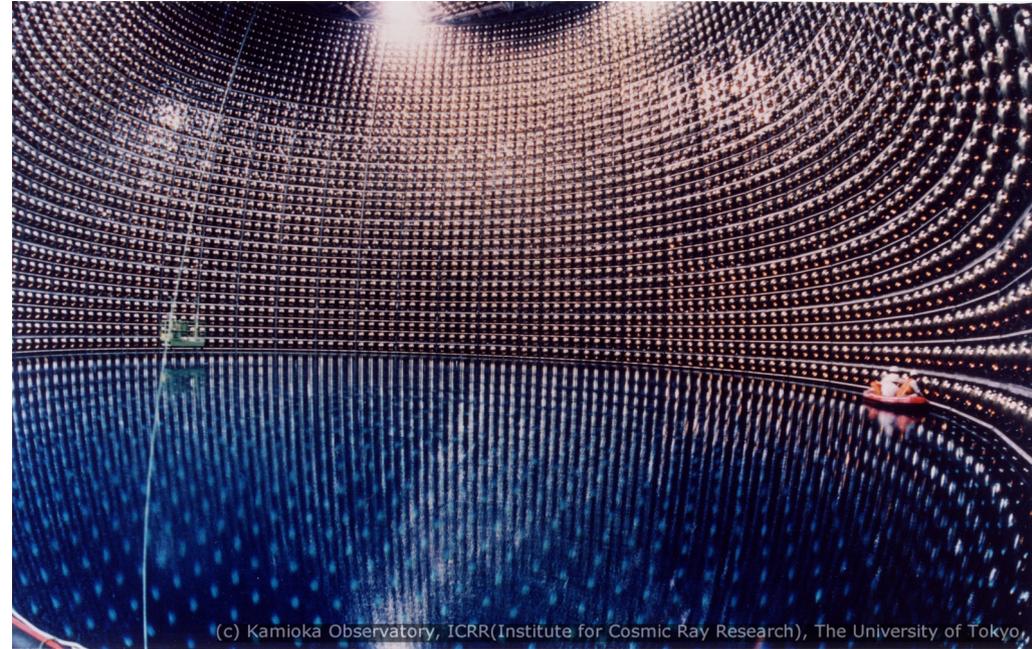
Nepomuk Otte

School of Physics
&
Center for Relativistic Astrophysics



Photodetector Applications in Physics

- Used to detect:
 - Scintillation
 - Cherenkov
 - Fluorescence



Photoelectric Effect

- Discovered in 1887 by Hertz when exposing negative electrode to UV light.
- Explained by Einstein in 1905 → Nobel Prize

Light is quantized

$$E = h\nu = \frac{hc}{\lambda} = \frac{1240}{\lambda [nm]} eV$$

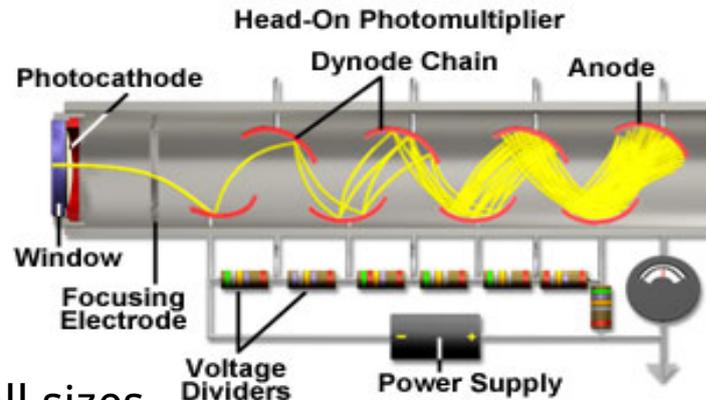
→ in order to create a free charge carrier a photon must have more energy than the binding energy of the charge carrier

Photomultipliers

- Most often used photon detector in HEP
 - High efficiency
 - Single photon response

But:

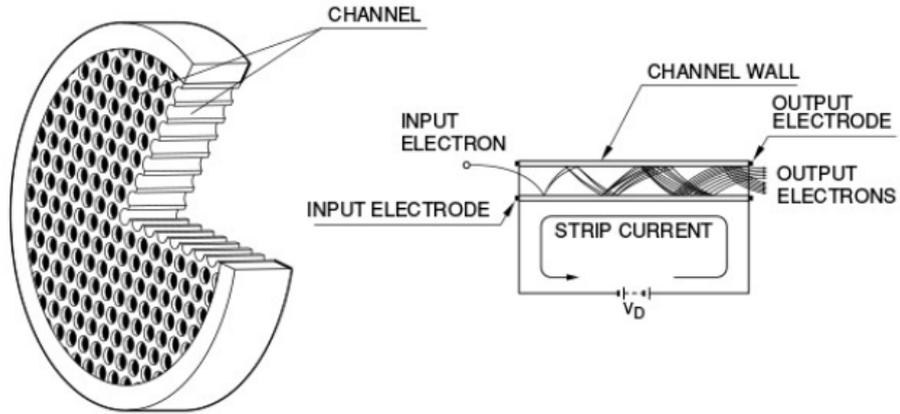
- Labor intensive production
- Glass → can break
- Bulky → difficult to scale to small sizes
- Needs high voltage
- Sensitive to magnetic fields



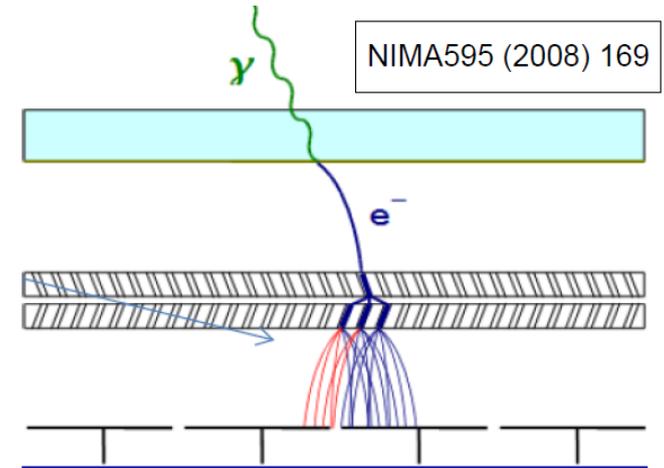
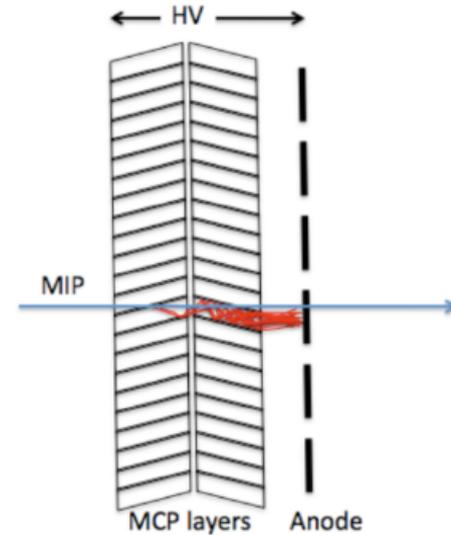
For an excellent resource on PMTs:

http://www.hamamatsu.com/resources/pdf/etd/PMT_handbook_v3aE.pdf

Micro Channel Plates



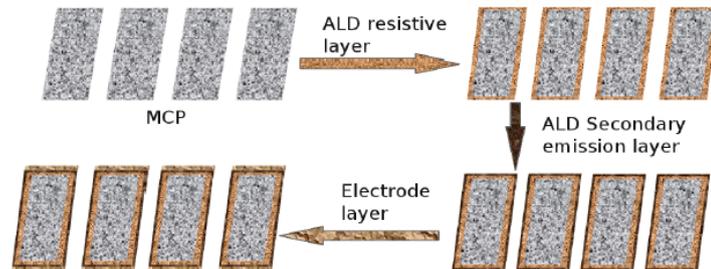
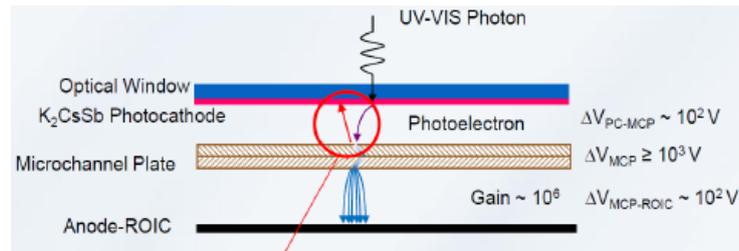
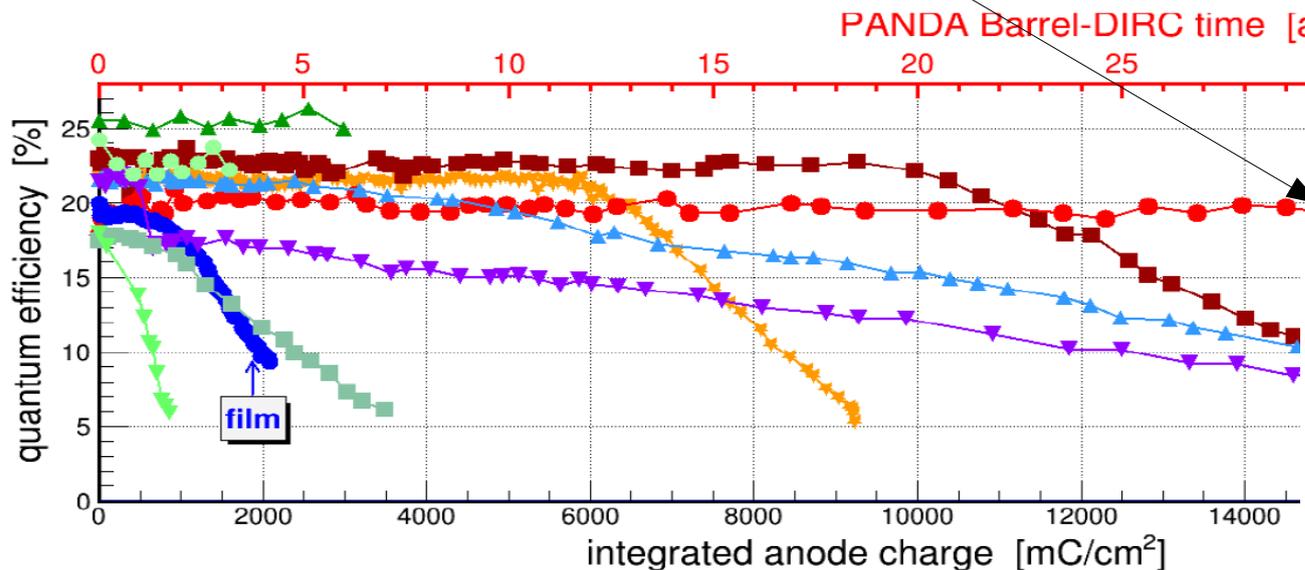
- Fast timing $< 30\text{ps}$ for single photoelectrons
- Channel diameters 5-26 μm
- Thickness 0.4 – 1 mm
- Gain > 1000
- Rate capability $\sim 1\text{MHz}/\text{cm}^2$
- Used as charged particle detector
- Or photon detector when combined with photocathode



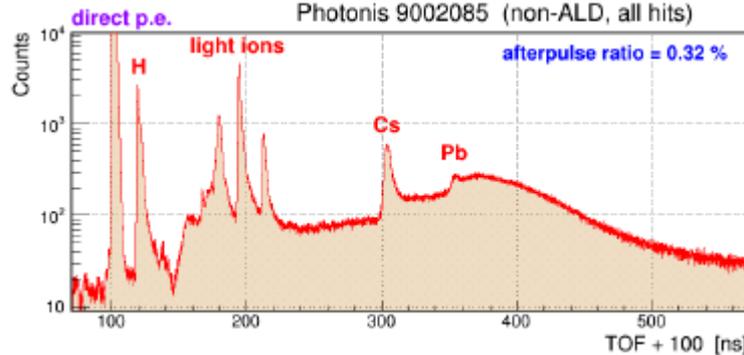
Aging (A. Lehmann)

- Atomic Layer Deposition was key to reduce aging

No sign of degradation after $15\text{C}/\text{cm}^2$



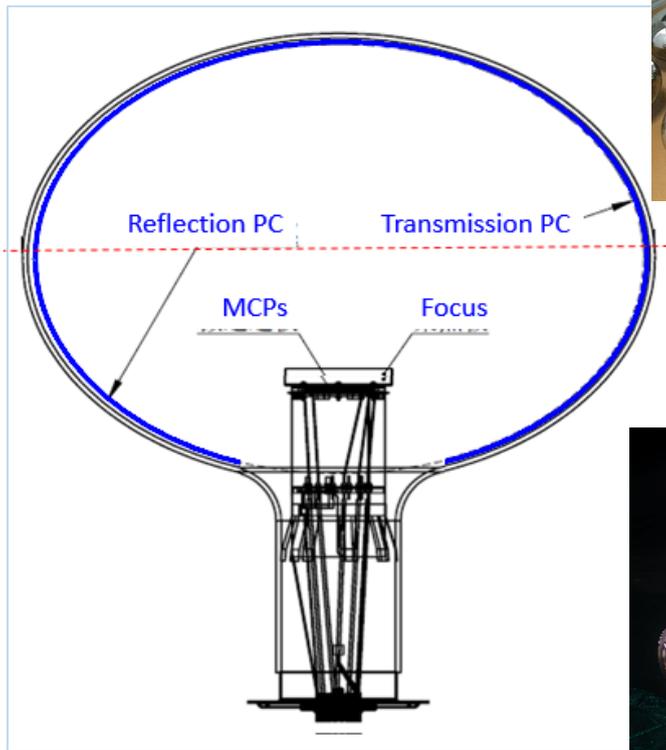
400 nm



★ PHOT. XP85112/A1-HGL (9001223)	■ PHOT. XP85112/A1-D (9001332)	● PHOT.
● Ham. R10754X-01-M16 (JT0117)	▲ Ham. R10754X-07-M16M (KT0001)	▼ Ham.
■ Ham. R13266-07-M64 (JS0022)	▲ Ham. R13266-07-M64 (JS0035)	▼ Ham. R13266-07-M768 (JS0018)
● Ham. R13266-07-M768 (JS0027)		

MCP PMTs for JUNO

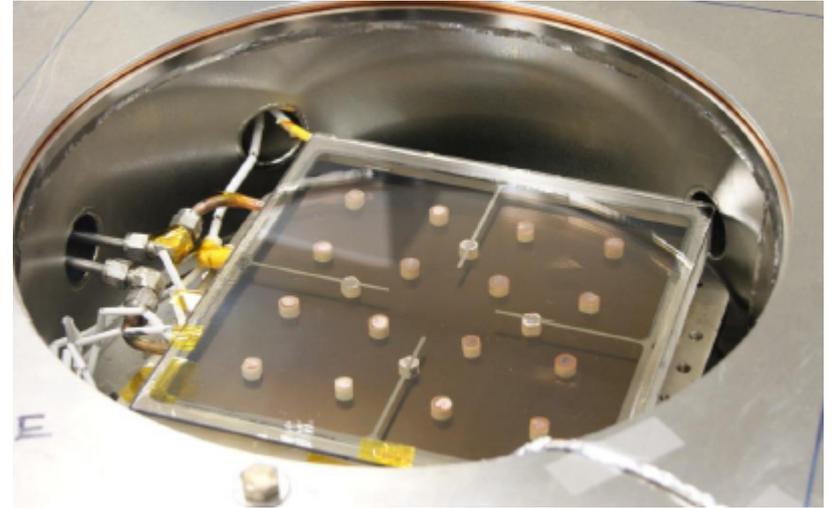
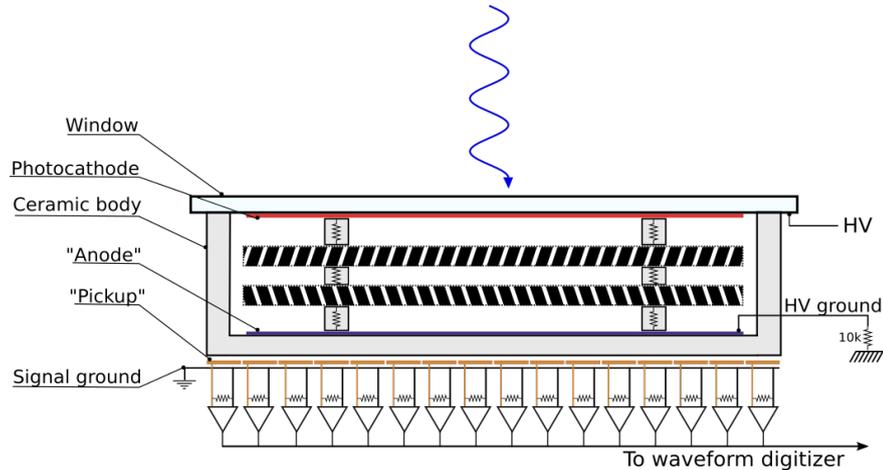
S. Qian



PMT Parameters	data in Contract	Prototype	2687 mass production
单波长 QE@410nm	$\geq 26.5\%$	~ 26%	29.2%
均匀性 (QE Uniformity)	$\leq 10\%$	$\leq 10\%$	7.7%
单光子探测 (SPE-P/V)	≥ 2.8	~ 5.6	6.9
能量分辨率 (SPE-ER)	$\leq 40\%$	~ 41%	33.4%
高压 (HV)	$\leq 2800V$	~ 1780V	1747V
探测效率 (DE)	$\geq 24\%$	~ 26%	29.2%
暗计数率 (DR)	$\leq 30KHz$	~ 30KHz	40.0 KHz
渡越时间涨落 (TTS)	$\leq 15ns$	~12ns	20.6ns
后脉冲率 (APR)	$\leq 5\%$	~ 2.5%	0.7%
非线性 (Linearity) <10%	$\geq 1000pe$	~ 1000pe	1293pe
信号波形 (RT)	$\leq 2ns$	~ 1.2ns	1.4 ns
信号波形 (FT)	$\leq 12ns$	~10.2ns	25 ns

Large Area Picosecond Photodetector

H. Frisch, A. Lyashenko, V. Fisher, B. Wagner

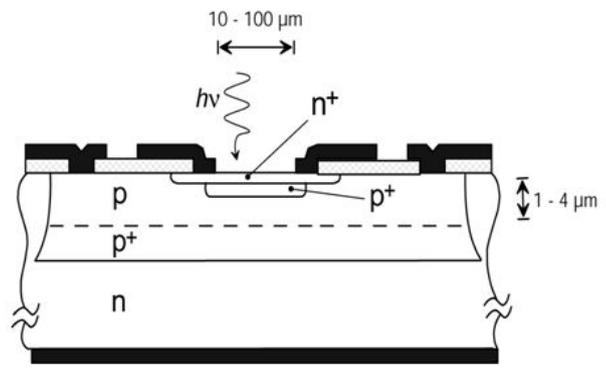
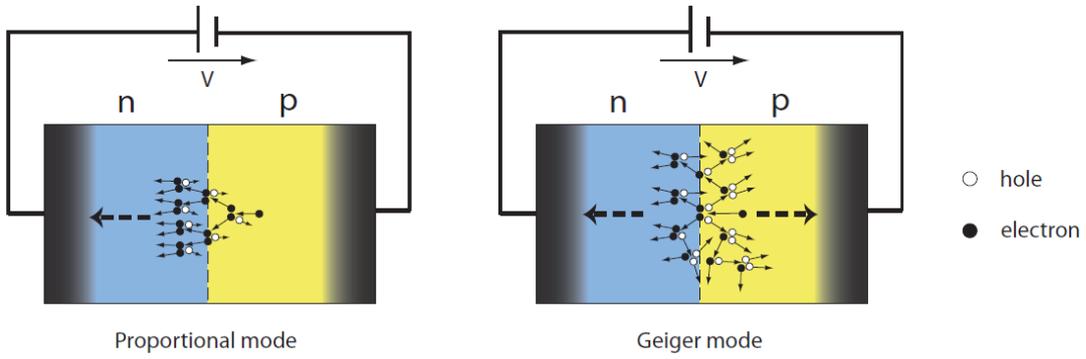


U. of Chicago

Make use of ps-timing:

- Optical Time Projection Chamber
- Collider proton/ch vertexing and track quark content

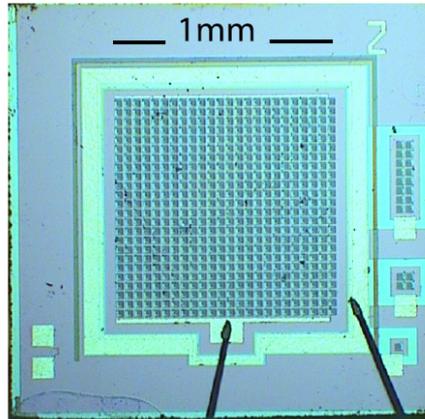
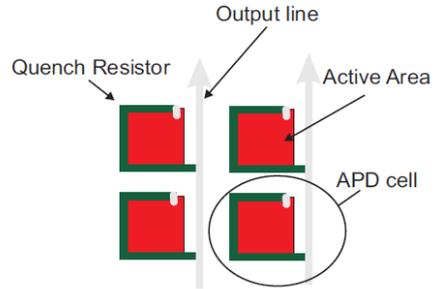
SPADs: P-N Junctions biased in Geiger Mode



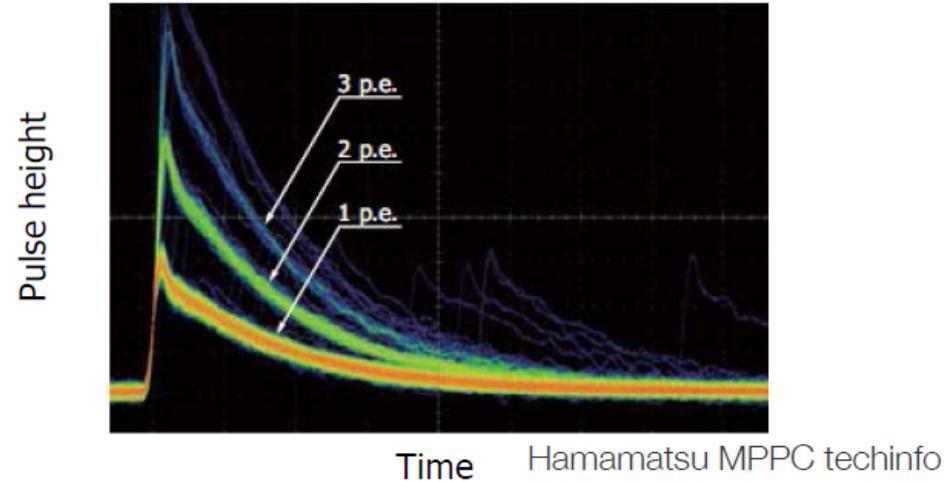
- Extensively studied in 60s, early 70s by Haitz, McIntyre, Oldham, ...
in the 90's by Cova, Lacaíta, ...
- Did the majority of the groundwork:
 - PDE, Optical crosstalk, afterpulsing, avalanche micro physics, quenching mechanisms, ...

The Geiger mode provides excellent signal to noise ratio (high "Gain") and sub-nanosecond timing

The SiPM



MEPhi/Pulsar SiPM 2004



The SiPM concept provides multi-photon resolution:

Many passively quenched SPADs are connected in parallel

Recover information about number of photons
if photons per cell per recovery time < 1

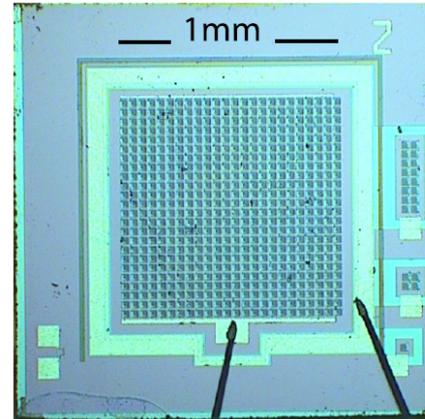
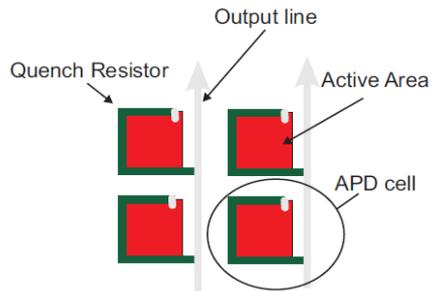
Pioneered in the 90's

Key persons: Dolgoshein, Golovin, and Sadykov

For an extensive review on the history of solid state photon detectors see D. Renker and E. Lorentz (2009)

The Silicon Photomultiplier

- Compact
- Optical and electrical robust
- Low intrinsic radioactivity
- Plus all the advantages of photomultiplier tubes
- Ideal where small photon detectors are needed

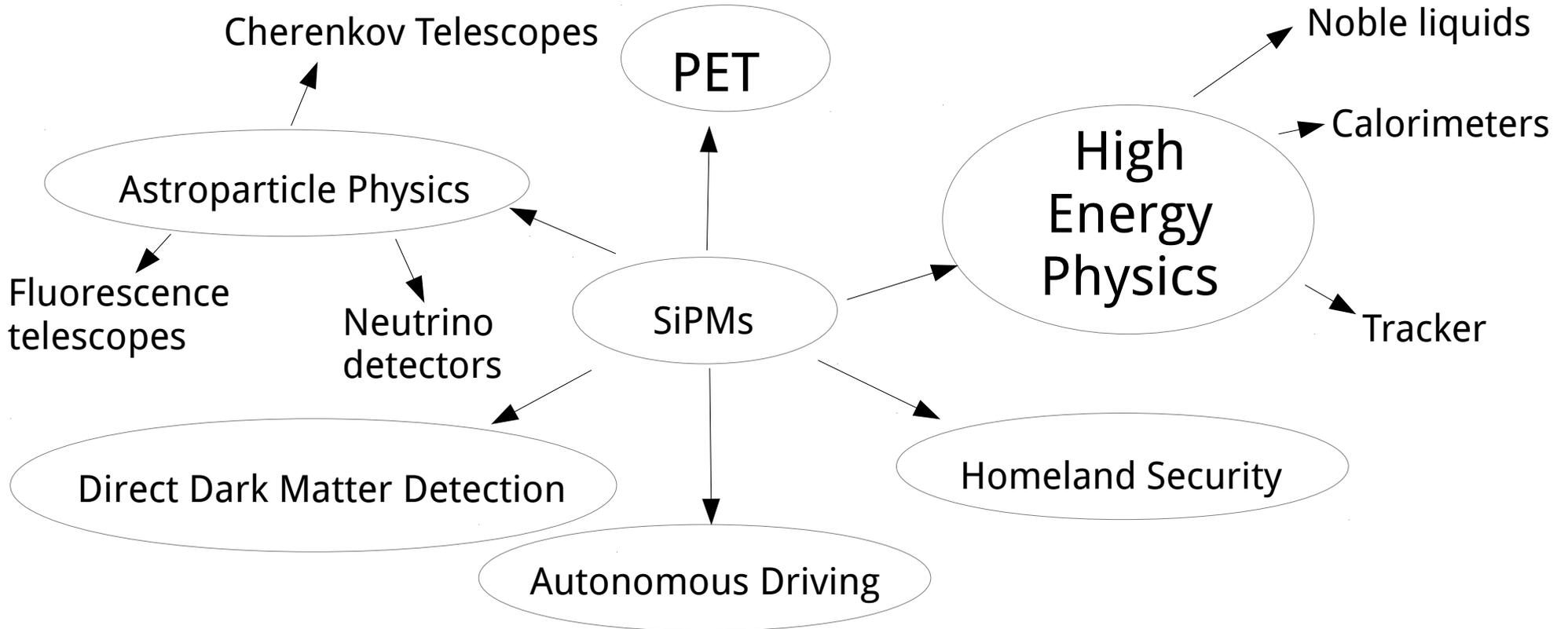


History of Key SiPM Parameters

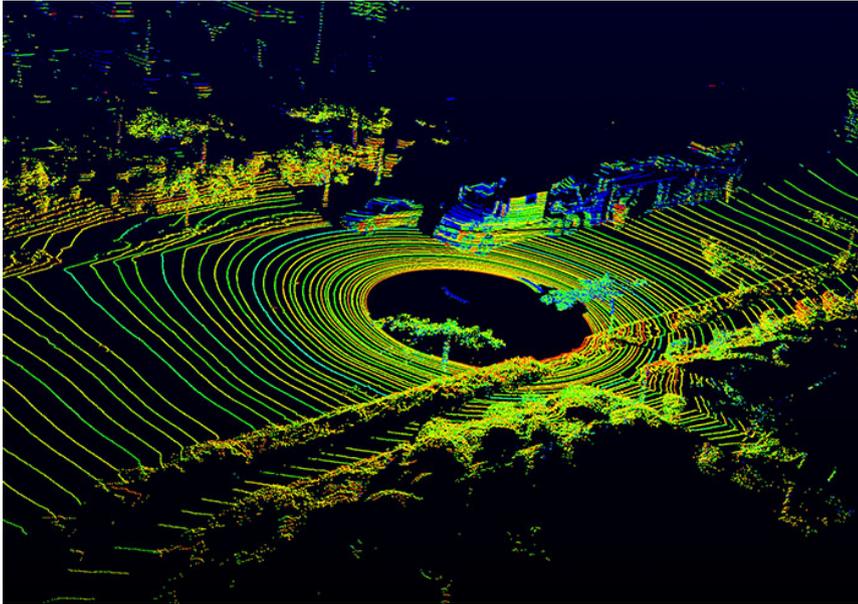
Parameter	2004	2013	2017	Wish List
Spectral Response	Green Sensitive n-on-p structure	Blue and Green p-on-n structure	Blue and Green Enhanced below 350 nm	Tailored to application
Photon Detection Efficiency	~10%	~45%	~55%	>70%
Dark Noise At room temperature	1MHz/mm ²	~100kHz/mm ²	50 kHz/mm ²	As low as possible
Optical Crosstalk	>20%	<10%	1%	As low as possible
Afterpulsing	>20%	<1%	<1%	As low as possible
Temperature dependency of gain	5-10 %/°C	5-10 %/°C	1 %/°C	
Sensor Size	1mm ²	1mm ² -36mm ²	1mm ² -36mm ²	

SiPMs are (fully?) mature devices
Due to rapid improvements in the past 17 years

SiPM Applications



SiPM Developments are driven by Multi-Billion Dollar Markets



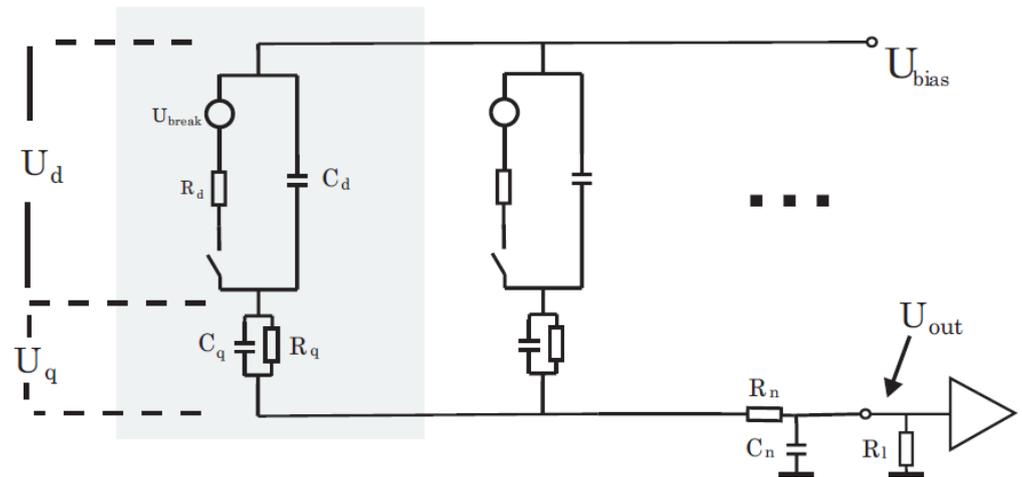
LIDAR



PET

SiPM Signals

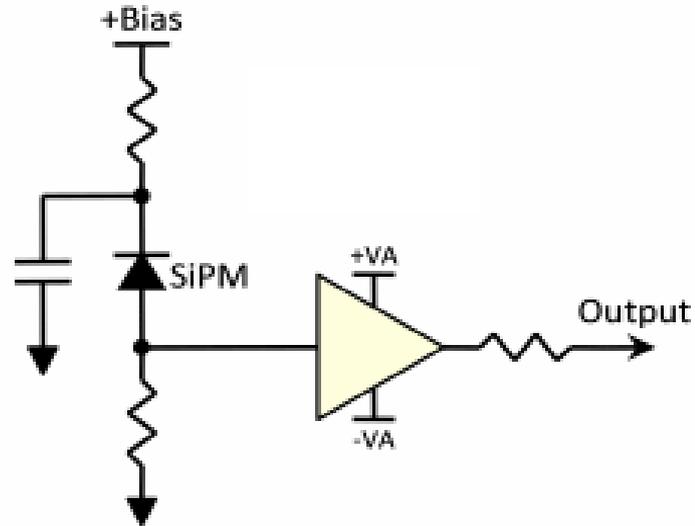
- Breakdown is quenched within 1 nanosecond
 - Produces fast current pulse
 - Dispersed by capacitance of network connecting cells
 - Signal proportional to overvoltage times effective cell capacitance
- Cell recharges after breakdown
 - Time constant determined by
 - Quench resistor
 - Effective cell capacitance



Otte (2007)

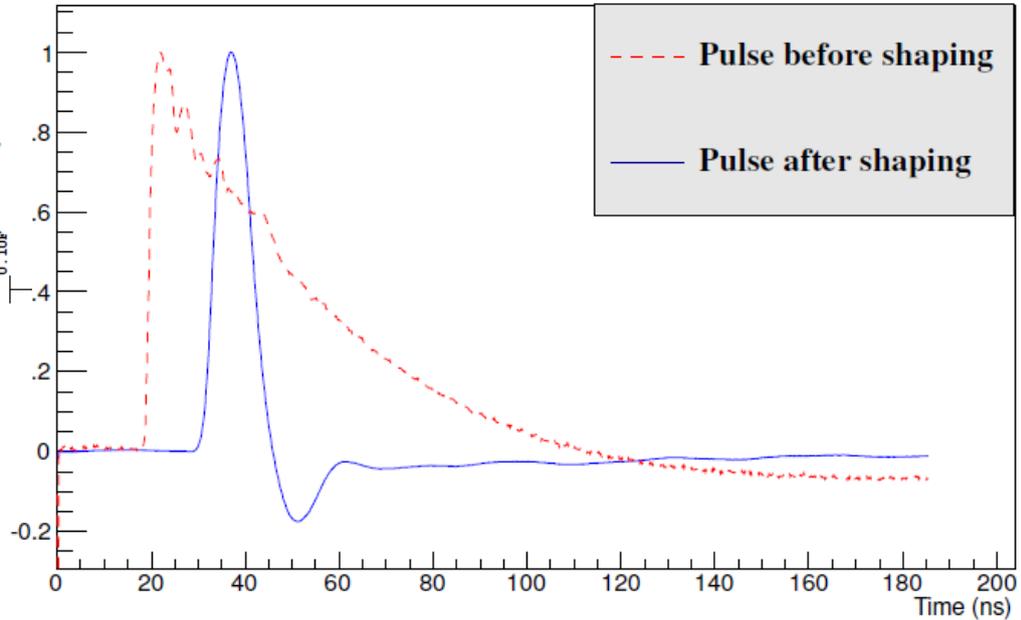
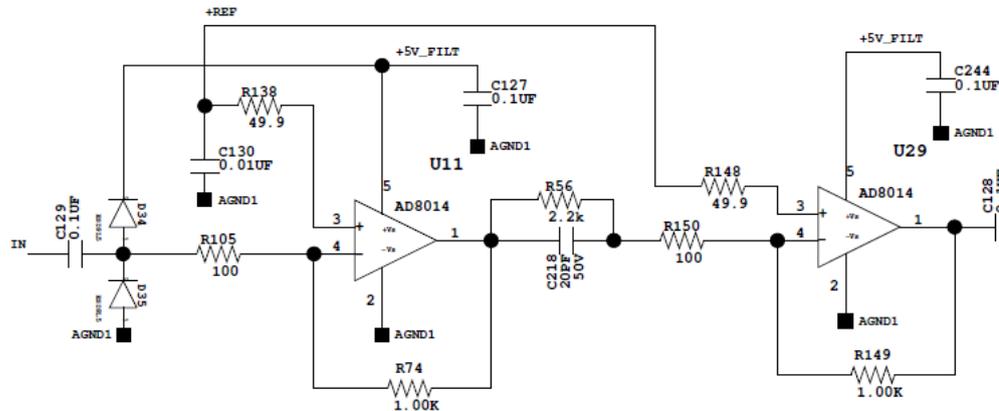
Hooking up SiPMs

- Typical bias: ~30 V



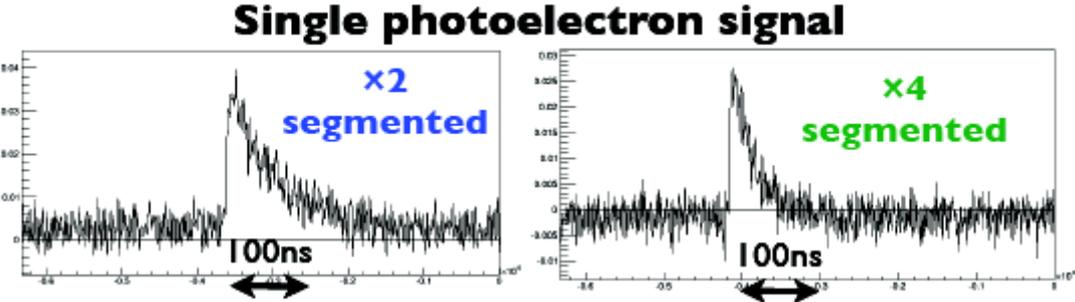
Signal Shaping

- Large SiPM capacitance requires low input impedance amplifiers
- And/Or shaping: Differentiation with pole-zero cancellation



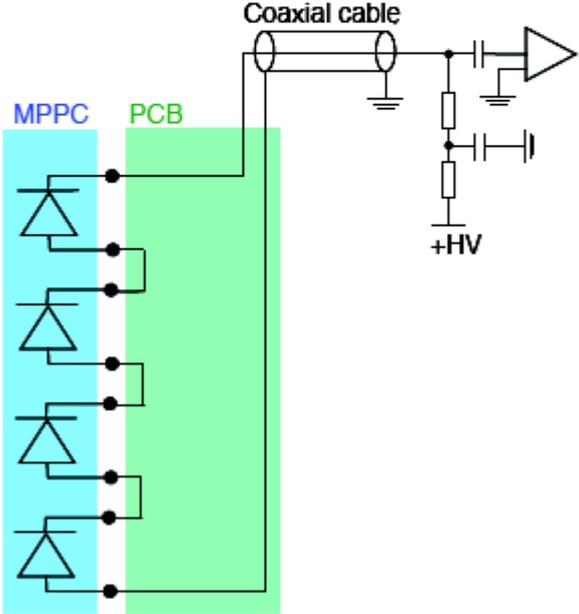
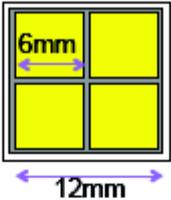
Otte, et al. (2015), DOI: 10.1016/j.nima.2014.11.026

Series Connection reduces effective Capacitance



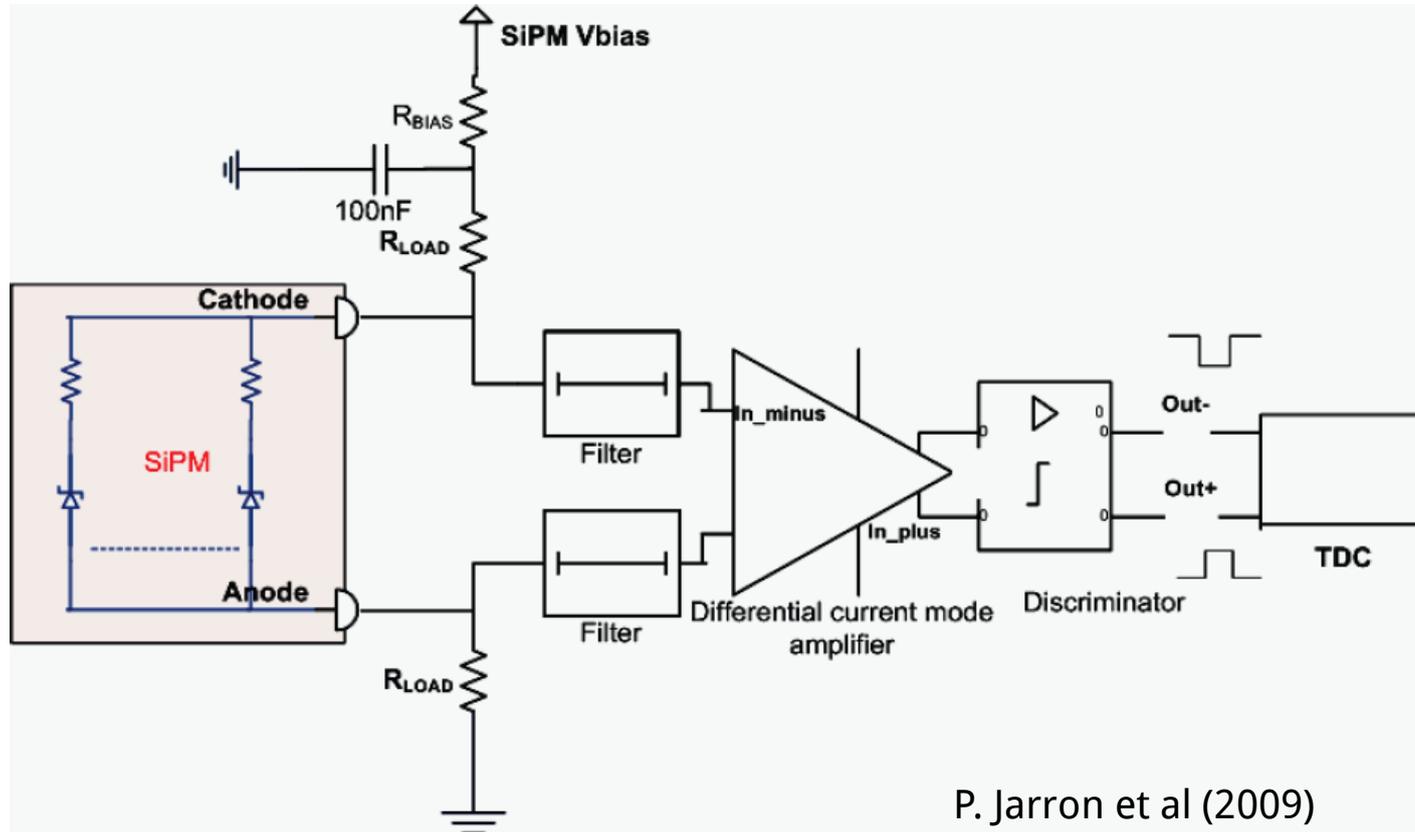
	Non-segmented	x2 segmented	x4 segmented
Fall time	200ns	45ns	25ns

Sensor segmentation (x4)



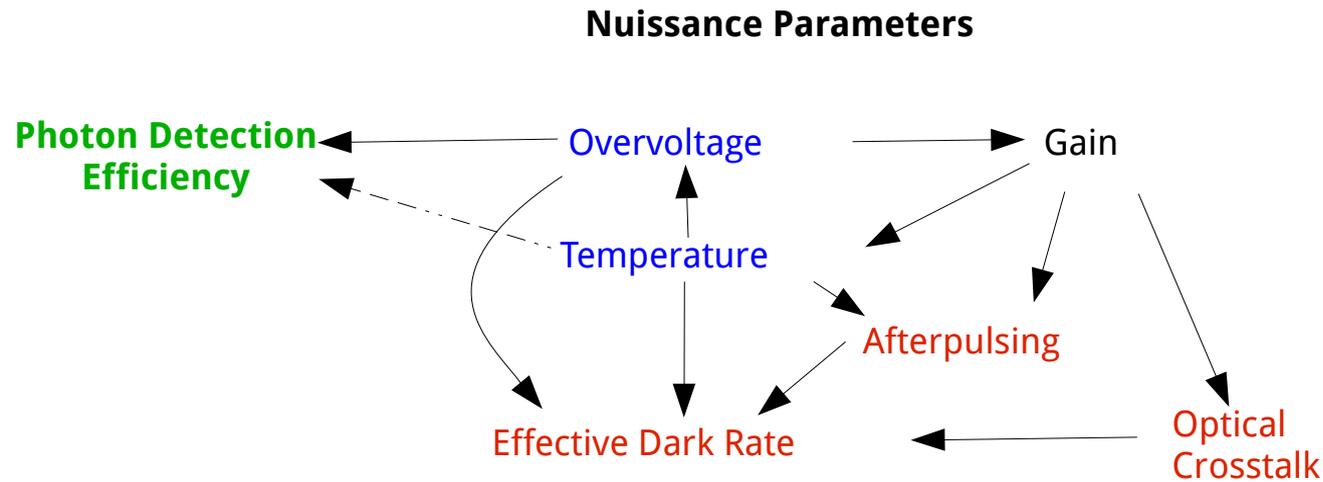
W. Ootani for the MEG Collaboration (2013)

Differential Readout

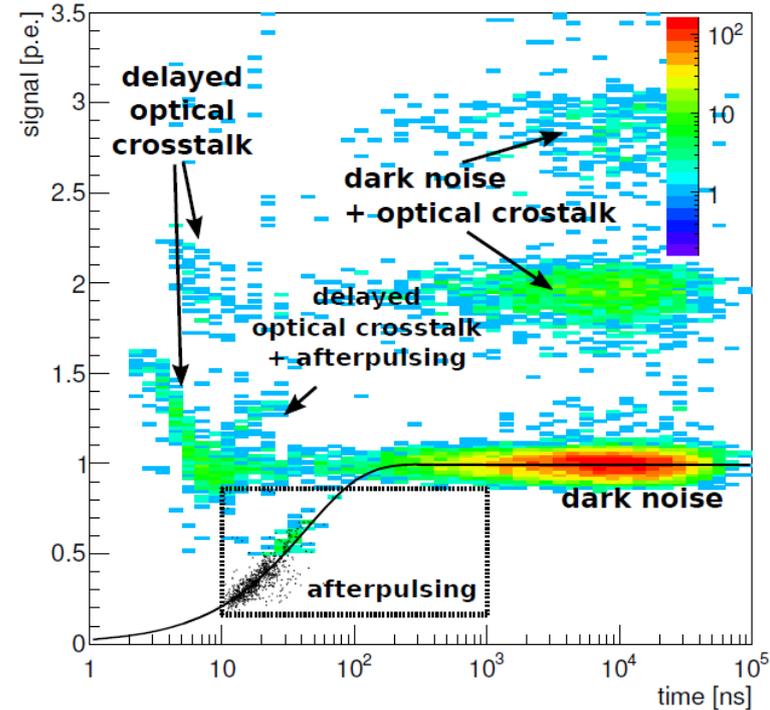


SiPM Parameters

User's perspective



Choice of bias has profound impact on SiPM performance in application



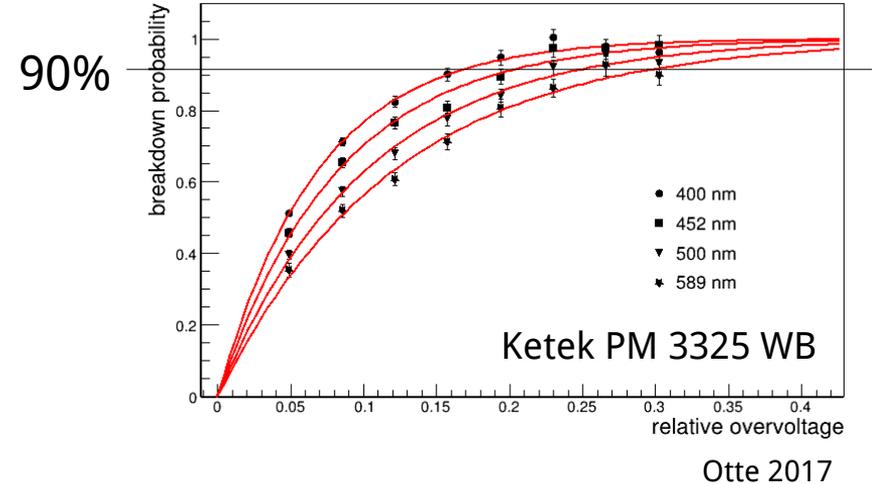
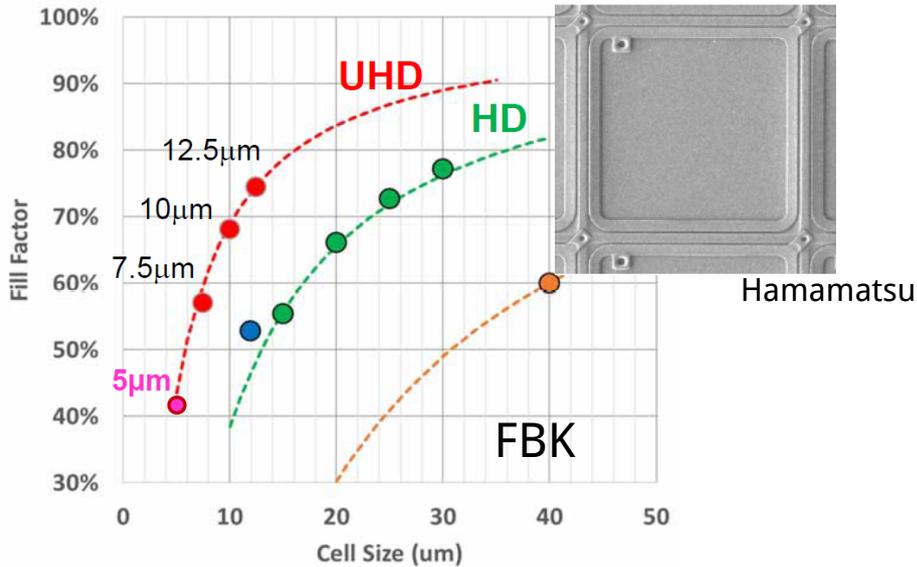
Otte et al. (2017)

Photon Detection Efficiency

geometrical efficiency *
 >80%
 For >50 μ m cells

transmission * effective QE
 >90% >90%
 Values are quoted for peak response

* breakdown probability
 90%



Photon Detection Efficiency

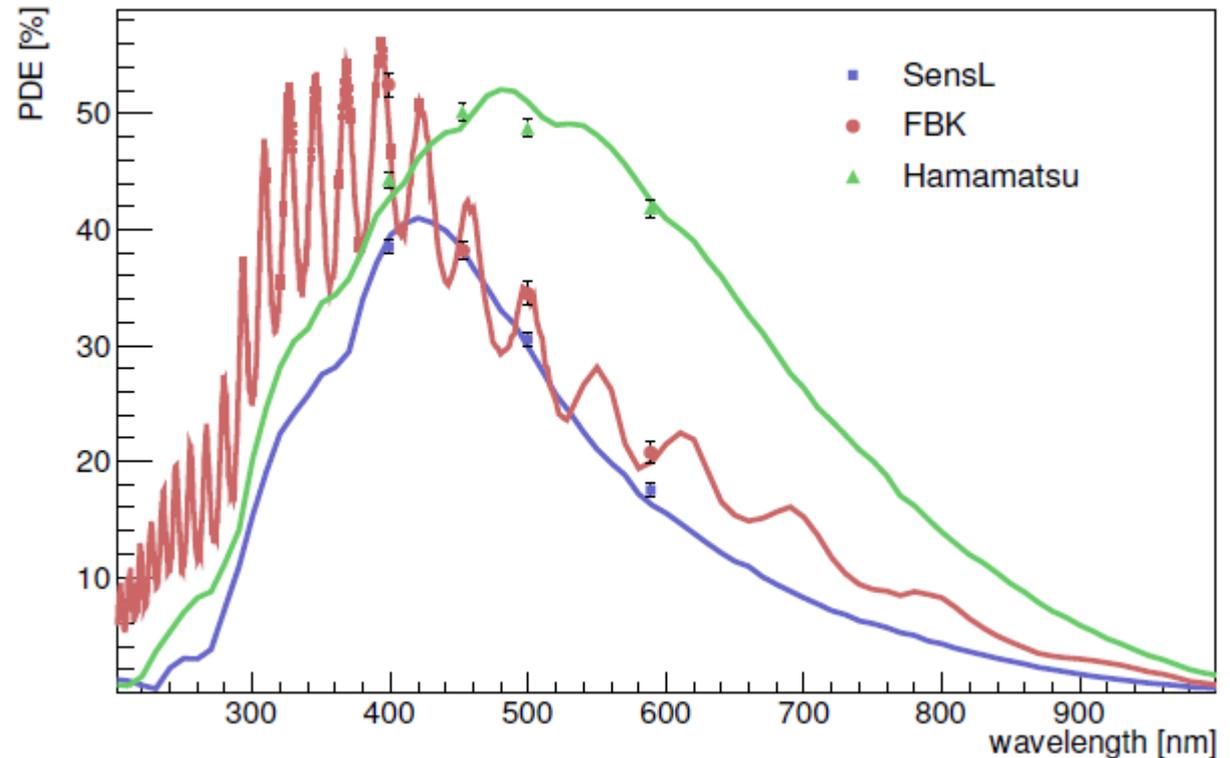
DOI:10.1016/j.nima.2016.09.053

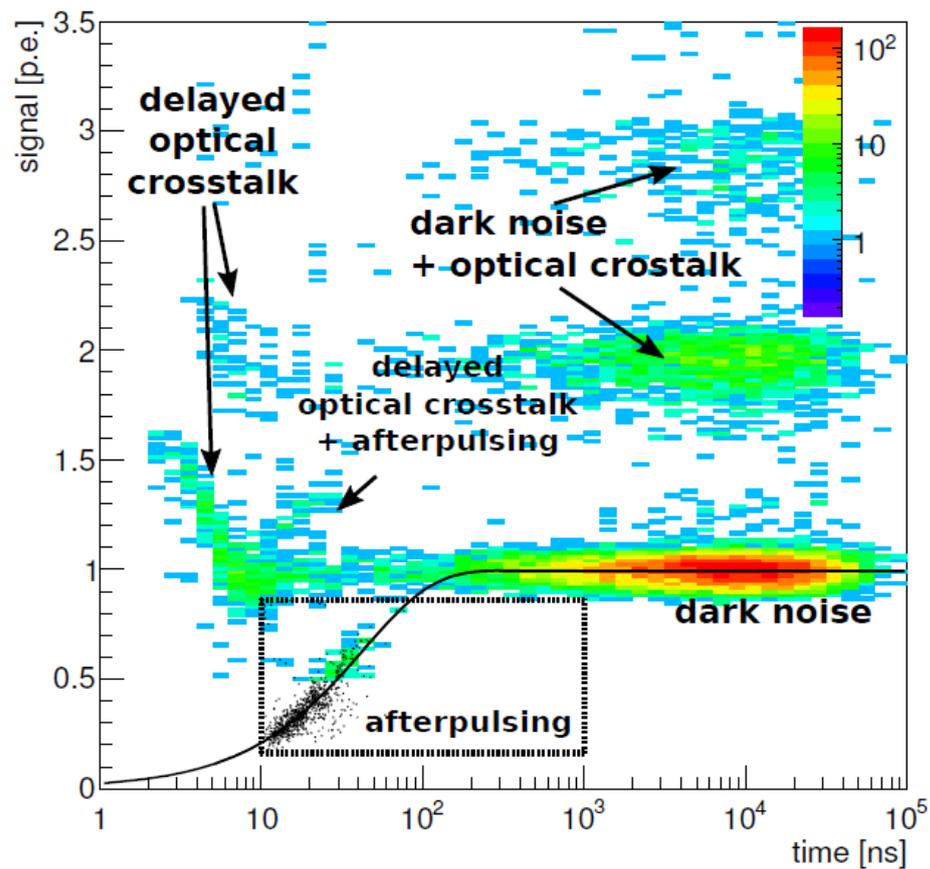
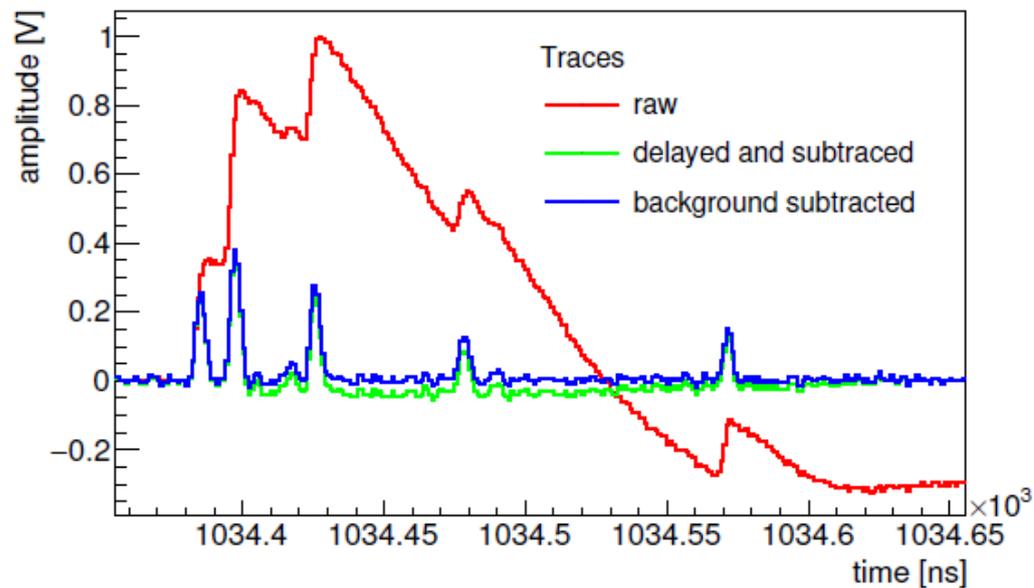
Otte et al. (2017)

SiPMs biased to achieve 90% breakdown probability @ 400nm

Have we reached the maximum possible peak PDE?

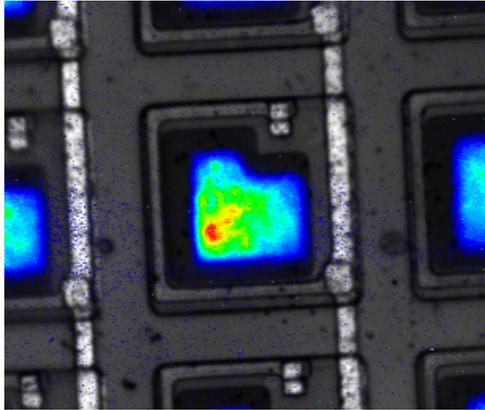
Maybe some more improvement possible but not much





DOI:10.1016/j.nima.2016.09.053

Optical Crosstalk



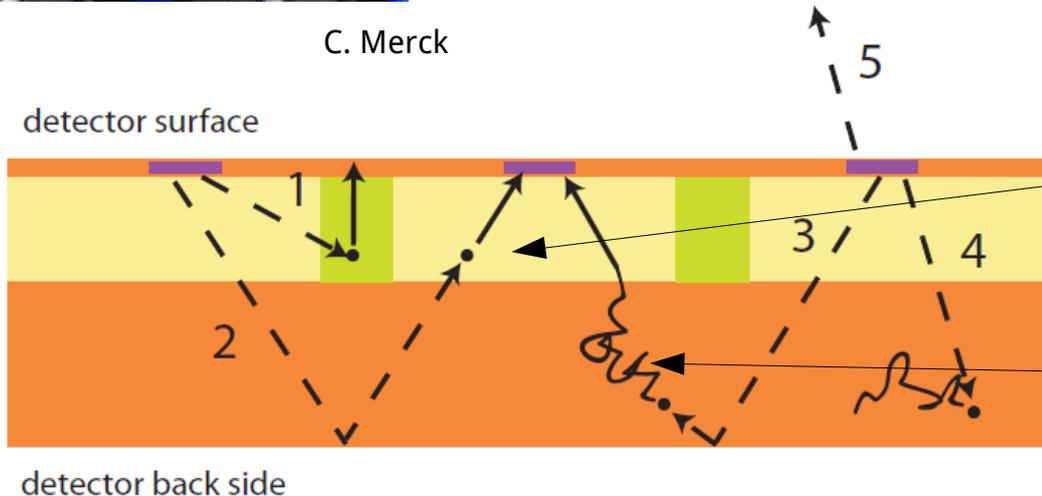
C. Merck

Photons are emitted during breakdown

Photon emission mechanism not well understood

Photons with $\lambda = 900\text{nm} - 1100\text{nm}$ have the right absorption length to produce optical crosstalk

$\sim 3 \cdot 10^{-5}$ photons per charge carrier in the breakdown



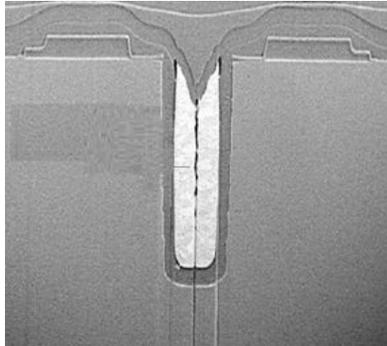
Direct/prompt optical crosstalk
Instantaneous $\ll 1\text{ns}$
→ pile up of signals

Indirect/delayed optical crosstalk
Delayed up to 100s of nanoseconds
→ contribution to afterpulsing
and effective dark rate

Direct Optical Crosstalk

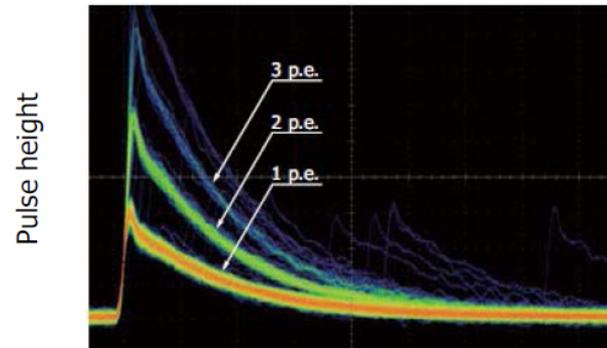
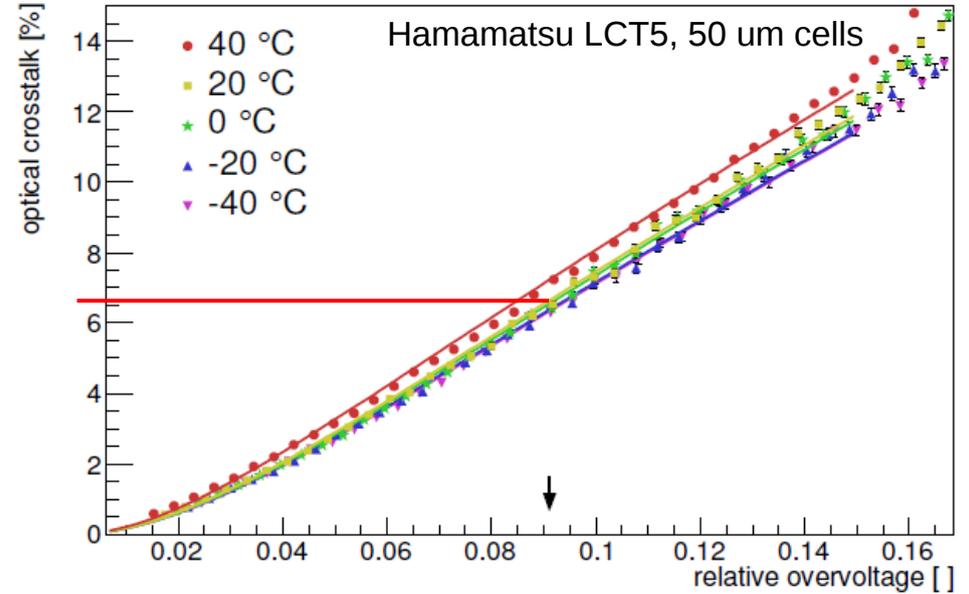
DOI:10.1016/j.nima.2016.09.053

- increase of accidental trigger rate
 - increase in trigger threshold
- increase in variance of detected signal
 - worse energy resolution



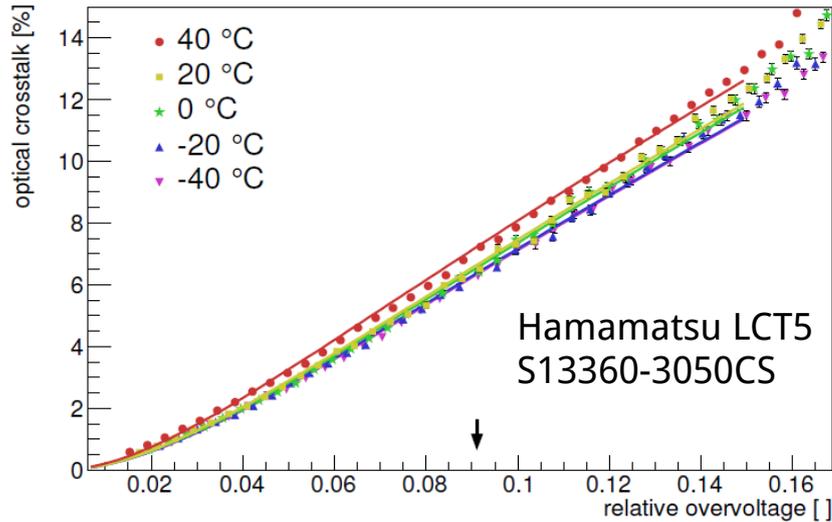
Hamamatsu

Optical isolation is key



Time Hamamatsu MPPC techinfo

Direct (Prompt) Optical Crosstalk (OC)



Gain* ϵ

Photons produced during breakdown

$$\epsilon = 3 \cdot 10^{-5} \text{ photons/charge carrier}$$

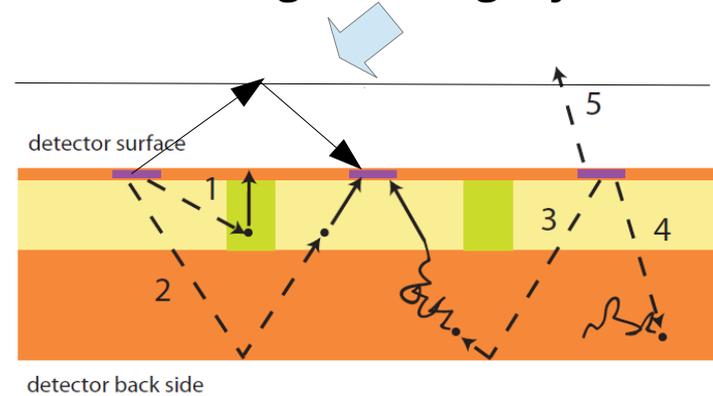
*

Optical crosstalk transmission factor

$$OC_{\text{transmission}} = 0.076$$

Nepomuk Otte

Dominant process: Xtalk photons bounce through coating layer



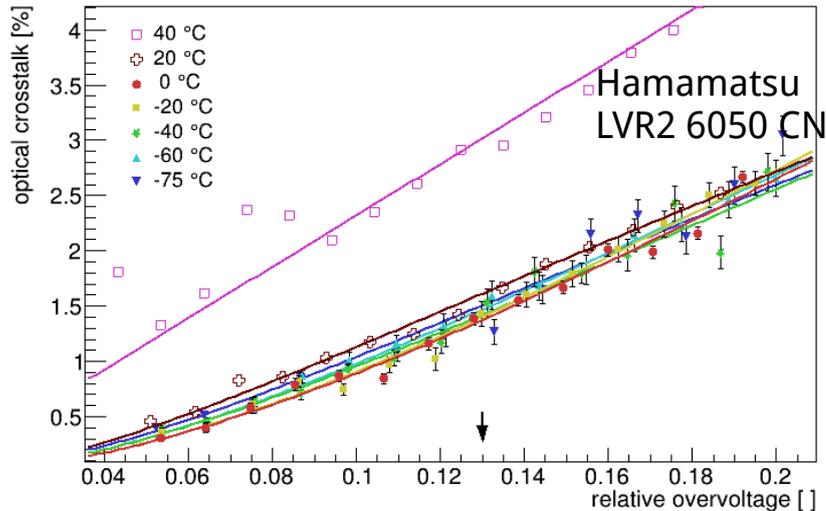
$$1 - e^{-\frac{U_{\text{rel. ov}}}{\alpha}}$$

Breakdown probability

$$\alpha = 0.040 \pm 0.001$$

Pure electron injected

Prompt OC in latest Hamamatsu LVR2



LVR2 with very thin coating

From Fit:

$$OC_{\text{transmission}} = 0.014$$

LVR structure (coating) suppresses OC five times better than LCT5

$$\alpha = 0.10 \pm 0.03$$

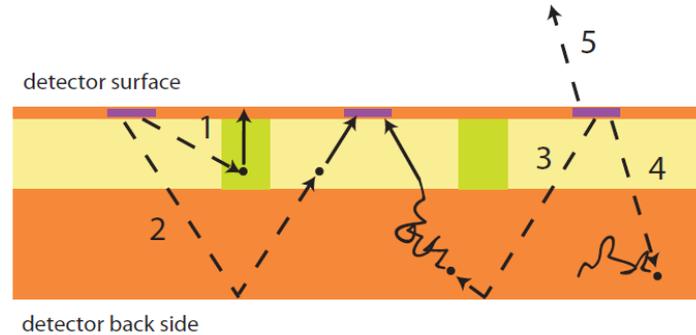
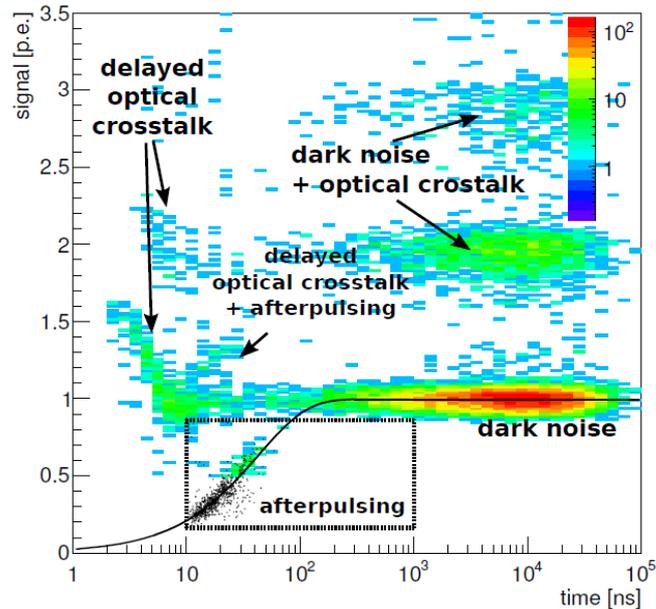
Remaining OC due to photons entering cell below avalanche structure

Prompt OC vs. afterpulsing in PMTs

The OC probability to get >4 pe pulses is 3×10^{-6}

→ lower than the probability to get >4pe pulses from afterpulsing in good PMTs ($1e-4$)

Delayed Optical Crosstalk



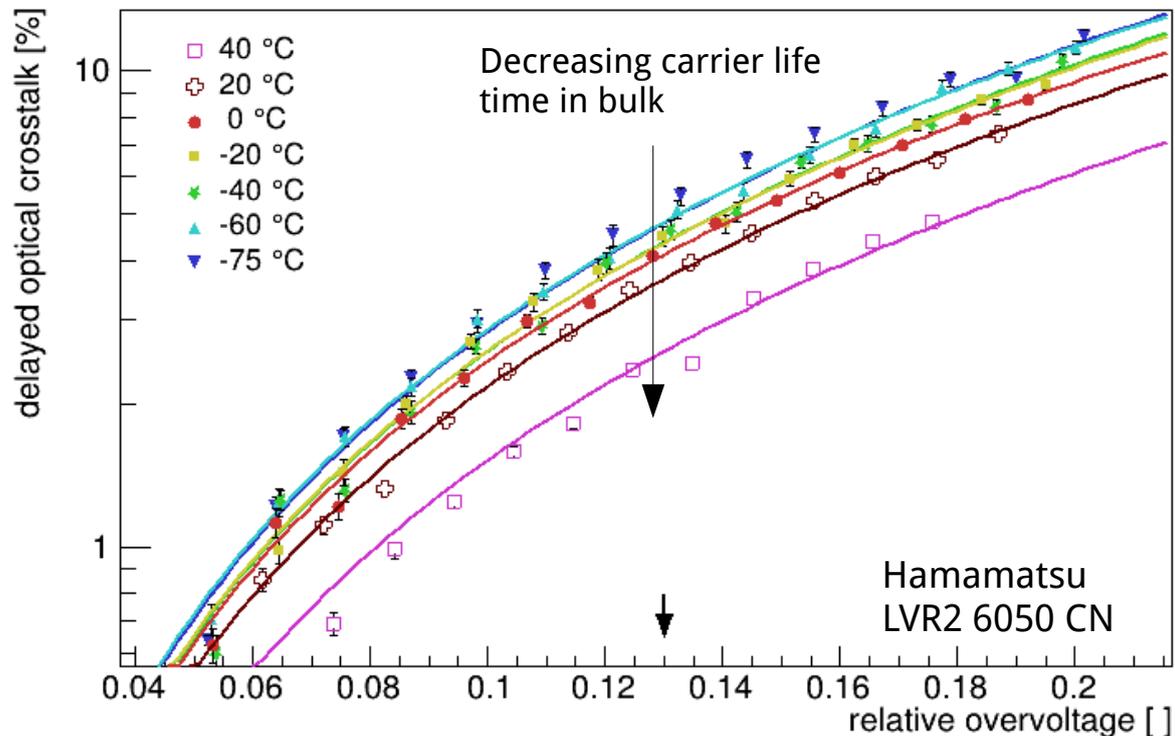
Measurement depends on how well two pulses can be separated

In our setup the minimum resolving time is 2 ns

All delayed OC signals with shorter delay are reconstructed as prompt OC signals

A late delayed OC signal comes from deeper inside the bulk → expect temperature dependency

Delayed Optical Crosstalk



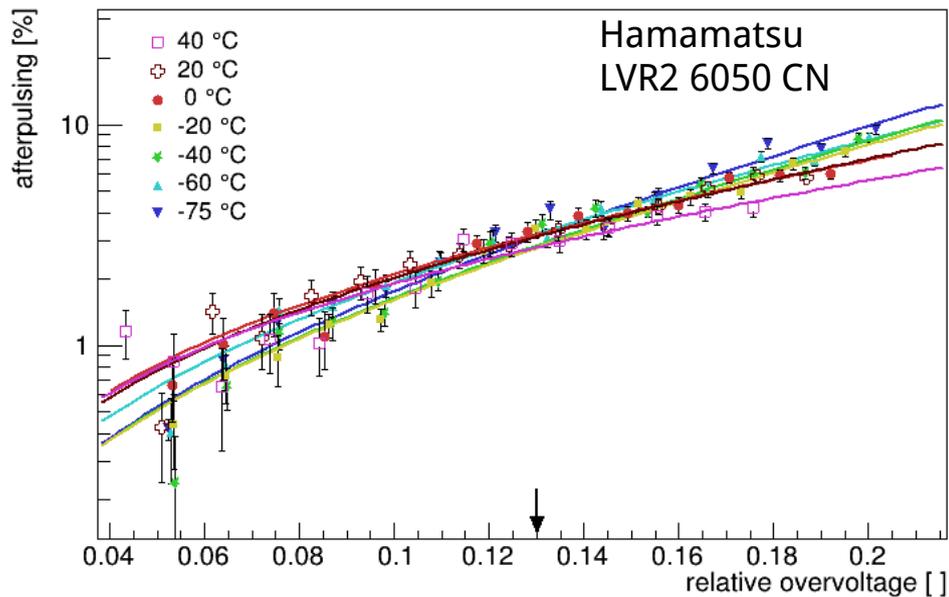
Same model to fit data as for prompt OC (does not include time dependence)

Uncertainties on fit too large to extract useful information

The temperature (and time) dependence has encoded the information about the carrier lifetime in non-depleted bulk

Delayed OC is 3 times higher than prompt OC in LVR2

Afterpulsing

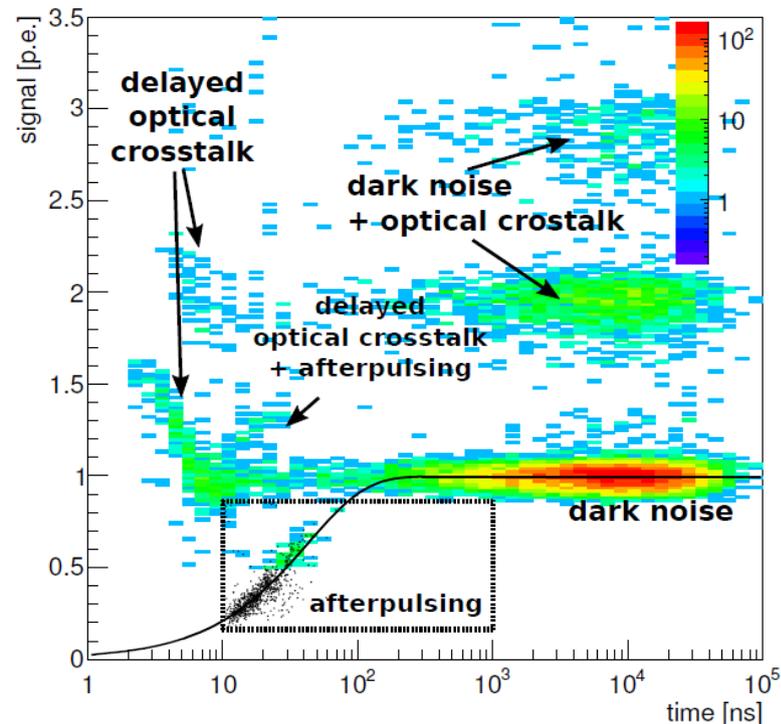


Fitfunction: $AP(U_{rel}) = A \cdot e^{(U_{rel}/\delta)} \cdot [1 - e^{(-U_{rel}/\alpha)}]$

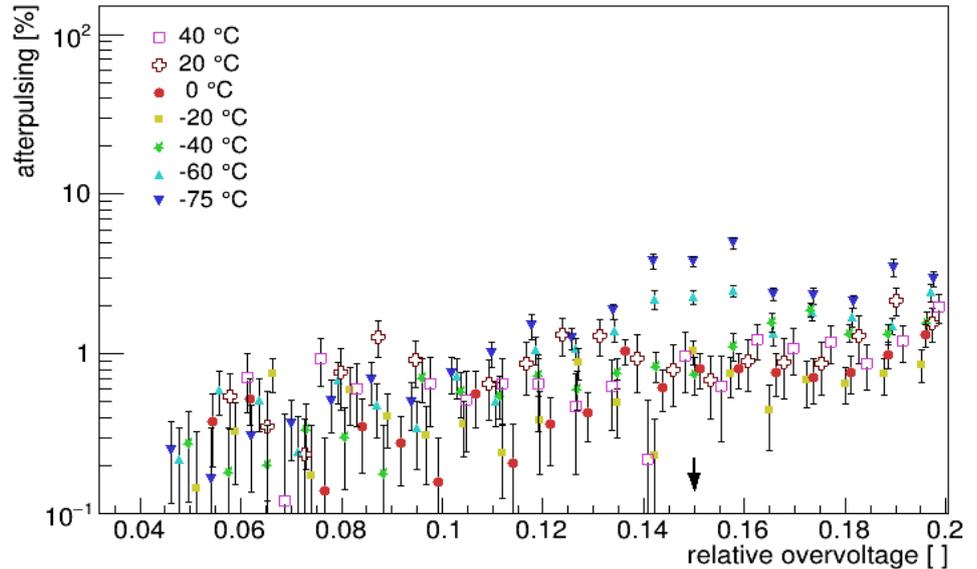
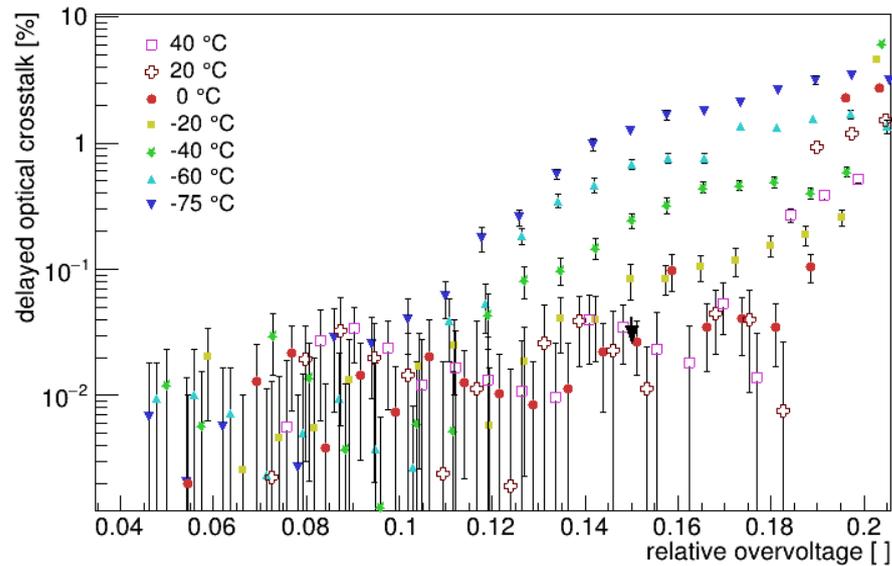
Notes:

Contamination from delayed OC and

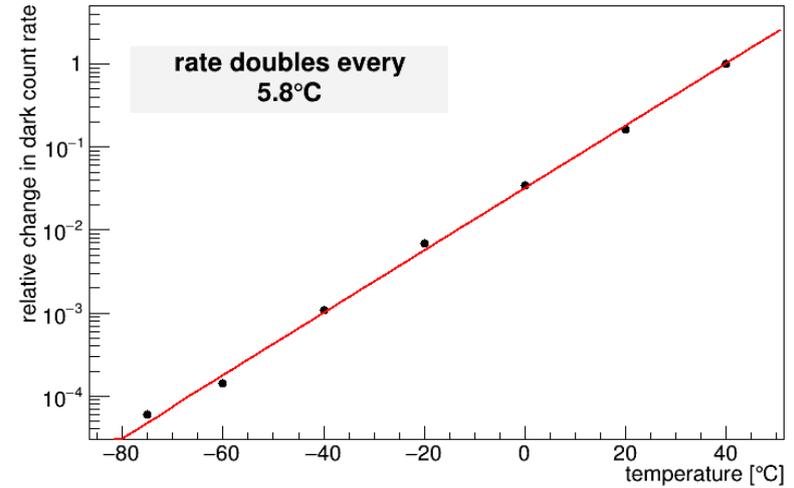
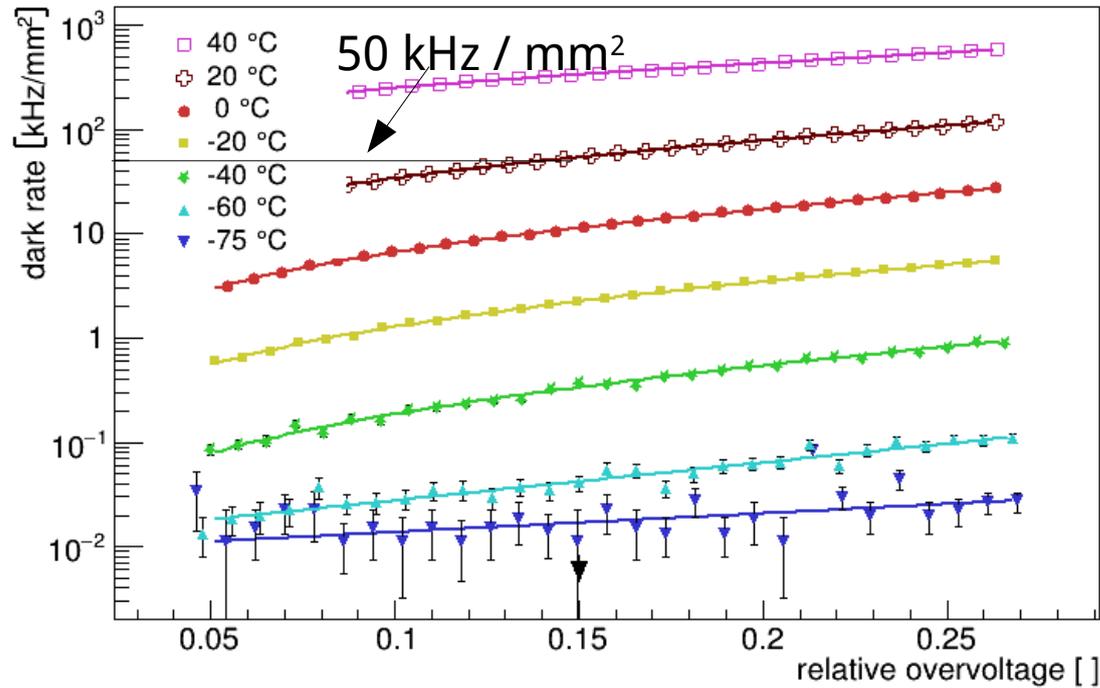
Minimum pulse height 0.5 pe



Afterpulsing and delayed OC in KETEK PM3325 WB



Dark-Count Rates

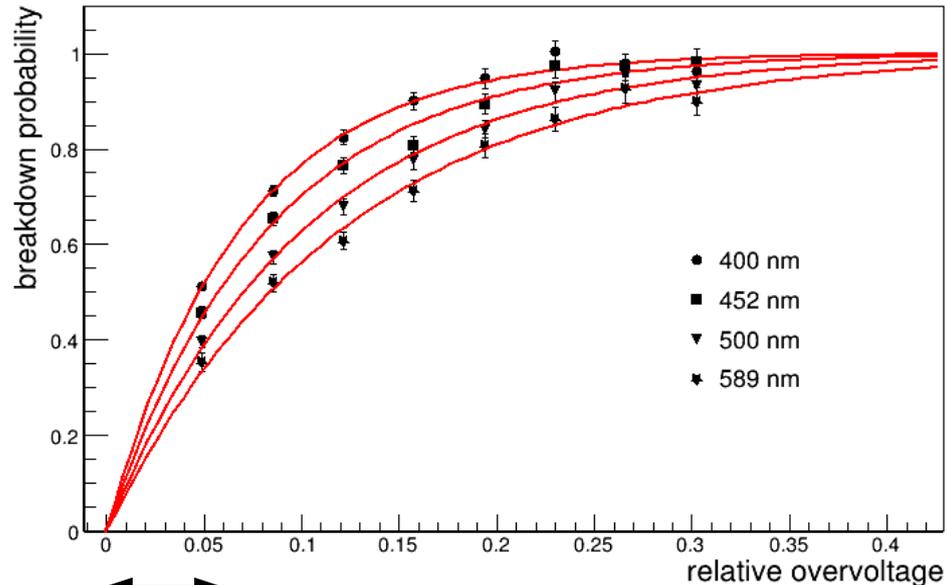


Ketek PM 3325 WB

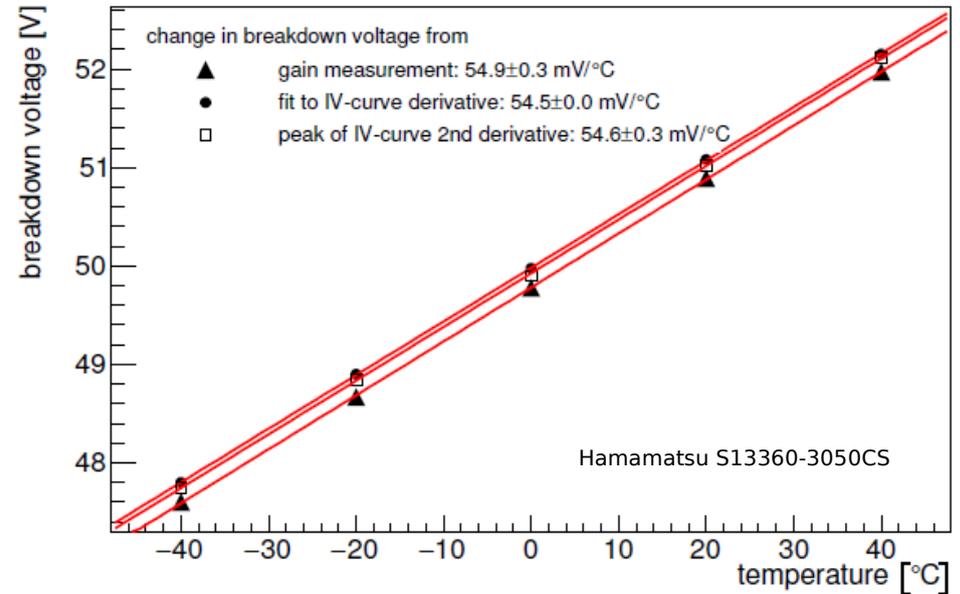
Temperature Dependence of PDE and Gain

arXiv:1606.05186

New devices operate at 10 – 20 % overvoltage
→ significantly reduces temperature dependence



Operating range of early devices



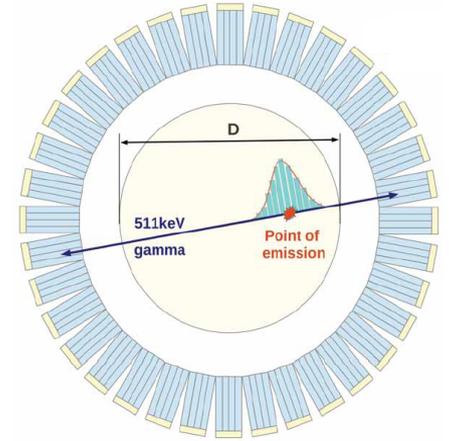
Gain changes: 0.5-1%/°C

PDE changes: 0.2-0.3%/°C

- modest temperature control to several °C is sufficient to keep PDE within +/- 2%
- changes in gain can be calibrated out

Timing

- Main driver is 10 ps FWHM timing resolution for TOF-PET
 - corresponds to range of positron before annihilation
- Allow shorter bunch crossing times in future collider experiments



<i>SiPM + LSO:Ce codoped with Ca coupled with Meltmount (n=1.68)</i>	<i>CTR [ps] 2x2x3mm³</i>	<i>CTR [ps] 2x2x20mm³</i>	<i>PDE [%] @ 410nm</i>	<i>SPTR [ps] FWHM</i>
HPK S13360 3x3mm ² (50μm)	85 ± 3	128 ± 5	62 ± 3	157 ± 7
HPK S13360 3x3mm ² (75μm)	80 ± 4	121 ± 4	67 ± 3	148 ± 7
Ketek PM 3350 3x3mm ² (50μm)	94 ± 5	150 ± 5	45 ± 3	223 ± 7
Sensl FJ 30035 3x3mm ² (35μm)	89 ± 3	140 ± 5	54 ± 3	277 ± 12
FBK NUV-HD 4x4mm ² (25μm) no resin	73 ± 2	117 ± 3	55 ± 3	193 ± 12
FBK NUV-HD 4x4mm ² (40μm) no resin	70 ± 3	112 ± 3	60 ± 3	129 ± 9

Individual SPADs achieve ~ 22 ps FWHM SPTR

M. V. Nemallapudi et al. (2016)

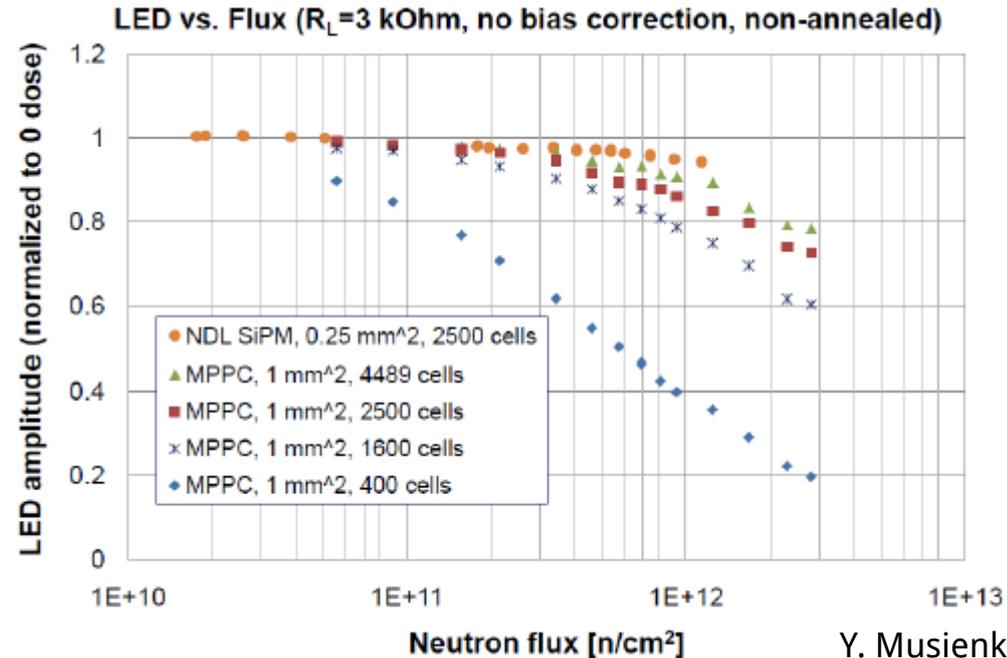
S. Gundacker (NDIP 2017)

Radiation Hardness

Radiation damage increases number of generation centers
→ higher dark count rates

Need:

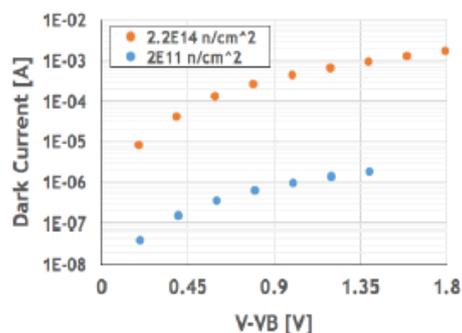
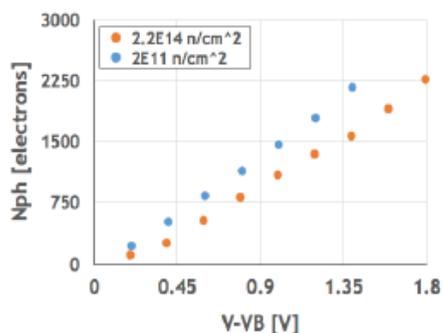
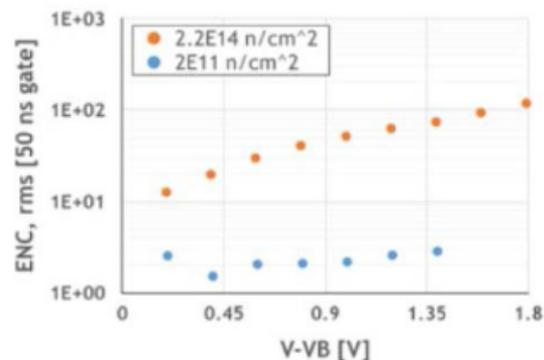
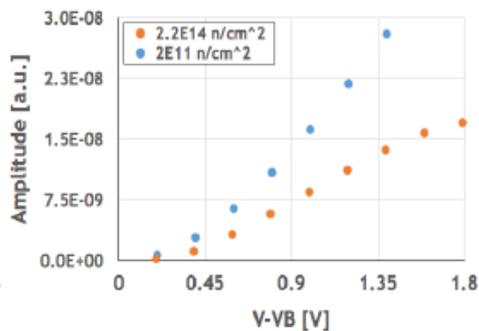
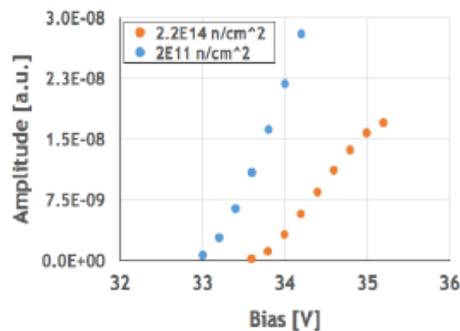
- High cell densities
- Fast recovery times



Y. Musienko (2015)

SiPM irradiated up to $2.2 \cdot 10^{14}$ n /cm²

Can SiPM survive very high neutron fluences expected at high luminosity LHC? Yes they can! FBK SiPM (1 mm², 12 μ m cell pitch was irradiated with 62 MeV protons up to $2.2 \cdot 10^{14}$ n /cm² (1 MeV equivalent).



We found:

- Increase of VB: ~ 0.5 V
- Drop of the amplitude (~ 2 times)
- Reduction of PDE (from 10% to 7.5 %)
- Increase of the current (up to ~ 1 mA at $dVB=1.5$ V)
- ENC(50 ns gate, $dVB=1.5$ V) ~ 80 e, rms

The main result is that SiPM survived this dose of irradiation and can be used as photon detector!

(A.Hearing et al., NIM A824 (2016) 111)

Backup

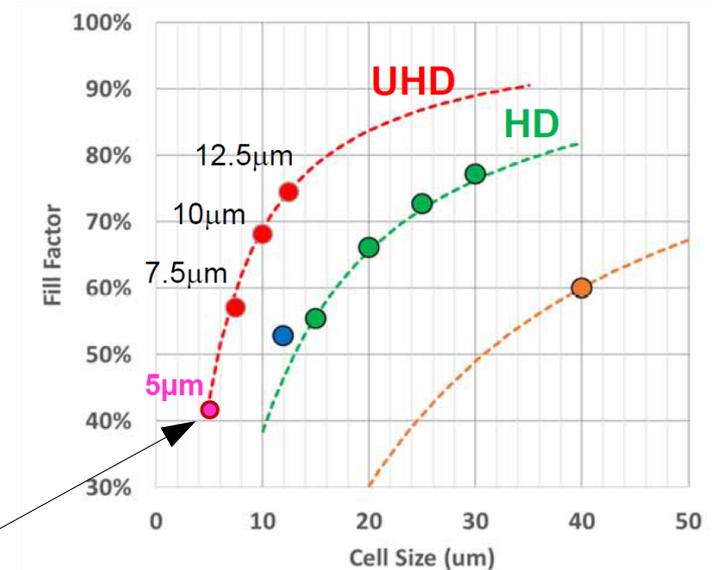
Dynamic Range

- Important for calorimeter applications
- Radiation hardness

Dynamic range depends on:

- cell density
- recovery time

5 μm cell sizes are in reach
Recovery times of 3-5 ns?



46,000 cells / mm²

Summary

SiPMs are mature devices:

- Enormous push in development by industry to serve mass market (PET, LIDARs)
- Further developments tailored to HEP/astrophysics applications must be funded by our own funding agencies
- SiPMs with prompt OC, delayed OC, and afterpulsing of less than 1% are possible
 - Expect devices with such features in the next 1-2 years
- SPTR of 10 ps are in reach?
- Reaching device performance limits determined by physics rather than technology

Blue sky developments:

Evolutionary:

- Push sensitivity in the VUV up → uncertain outcome, limited potential for improvement?

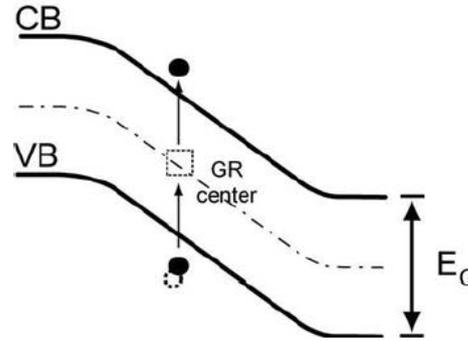
Revolutionary:

- Go for compound semiconductors → bypass physics limitations of silicon , face technological challenge instead

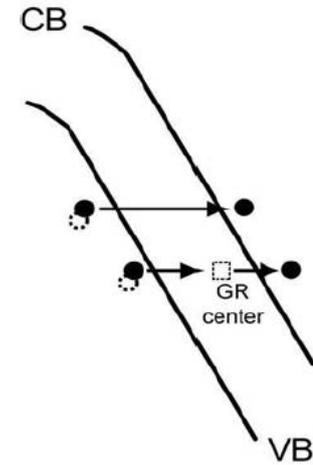
Effective Dark Rates

Contributions

1. thermal generated
2. tunneling
3. afterpulsing



Generation - Recombination Centers

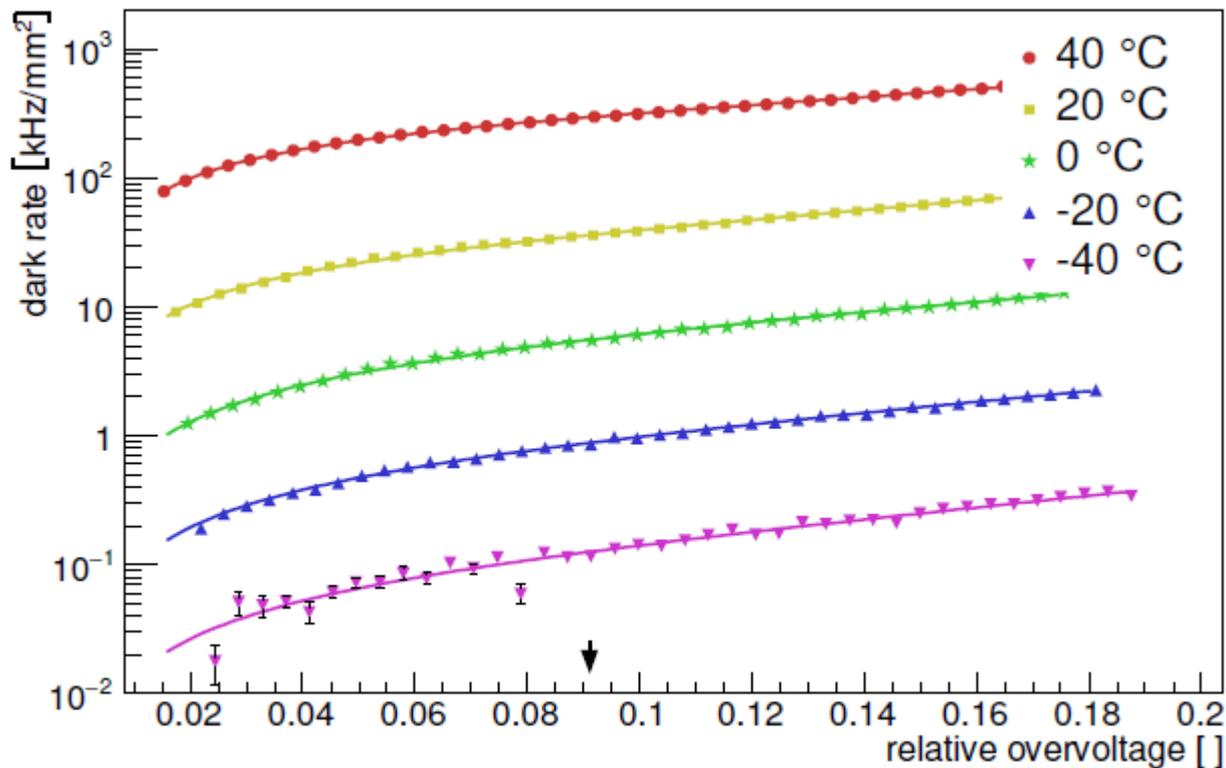


Field-Assisted Generation

Dark Rates

<50 kHz at room temperature is standard

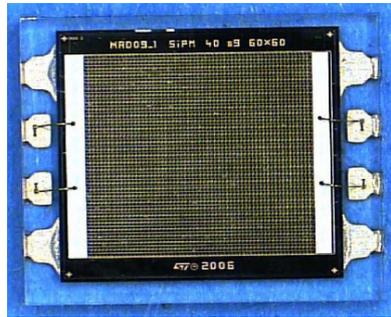
Can be cooled away



(b) Hamamatsu S13360-3050CS

SiPMs to detect steady Very-Low-Light Levels

Adamo et al. (2013)

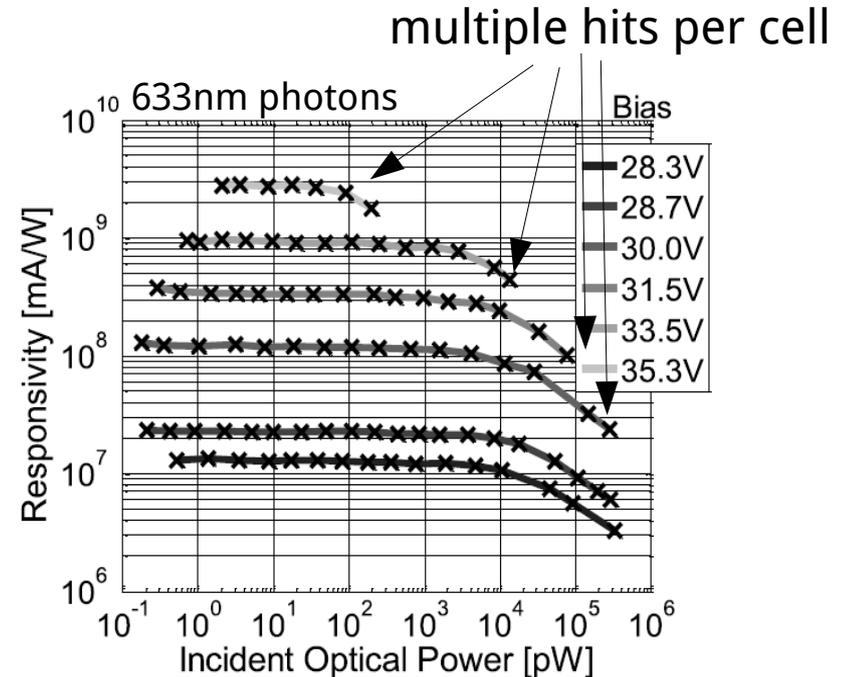


ST Microelectronics
3.5 x 3.5 mm²

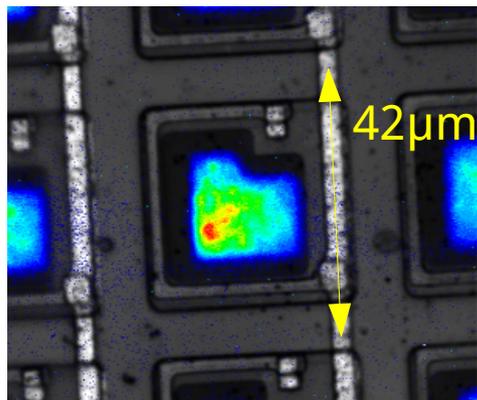
Sensitive to photocurrents of $\sim 10^{-15}$ A

Linear regime:

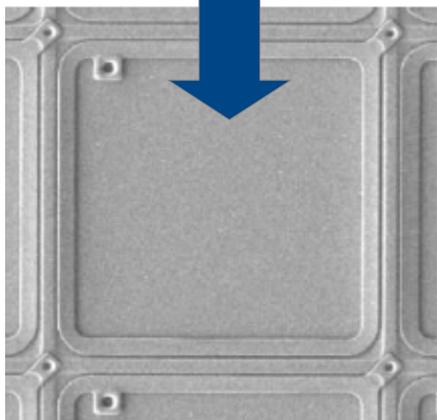
Acceptable photon rate for linear response
 $\ll 1$ photon / cell / recharge time



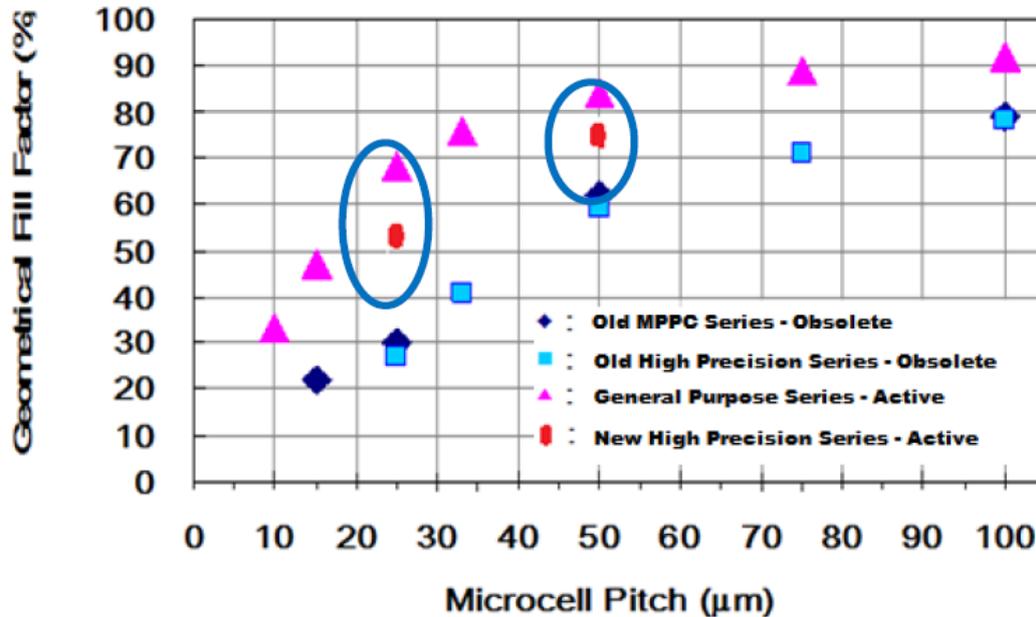
Geometrical Efficiency: intra-cell spacing



2004 MEPhI



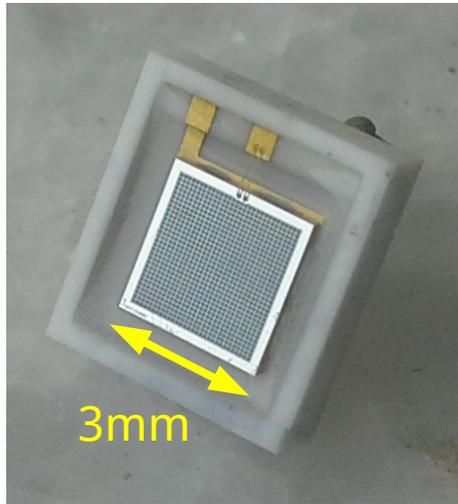
2014 Hamamatsu



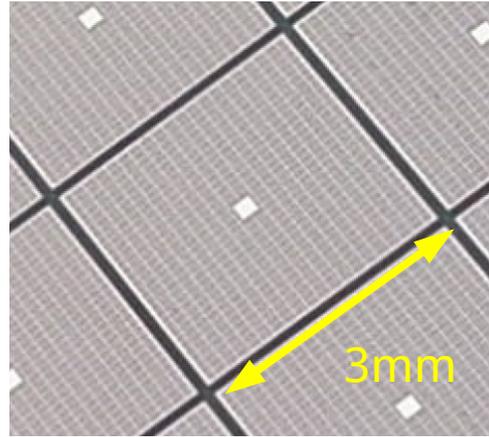
Hamamatsu

50% to 100% improvements depending on cell size

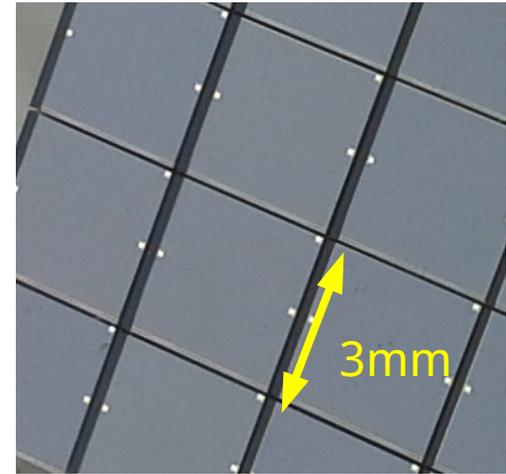
SiPMs Sizes



Hamamatsu 2008



Hamamatsu



SensL

Elimination of bond wires with through silicon vias

thinner guard ring around device

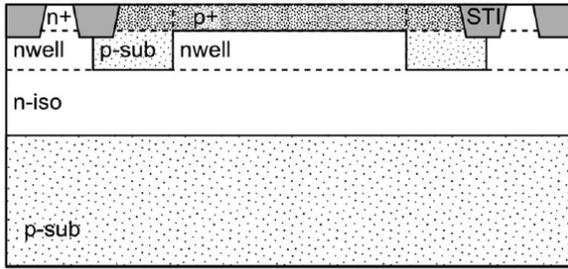
Chip packaging with much reduced gaps between chips

0.1 to 0.2 mm gap possible between chips → **>90% efficiency**

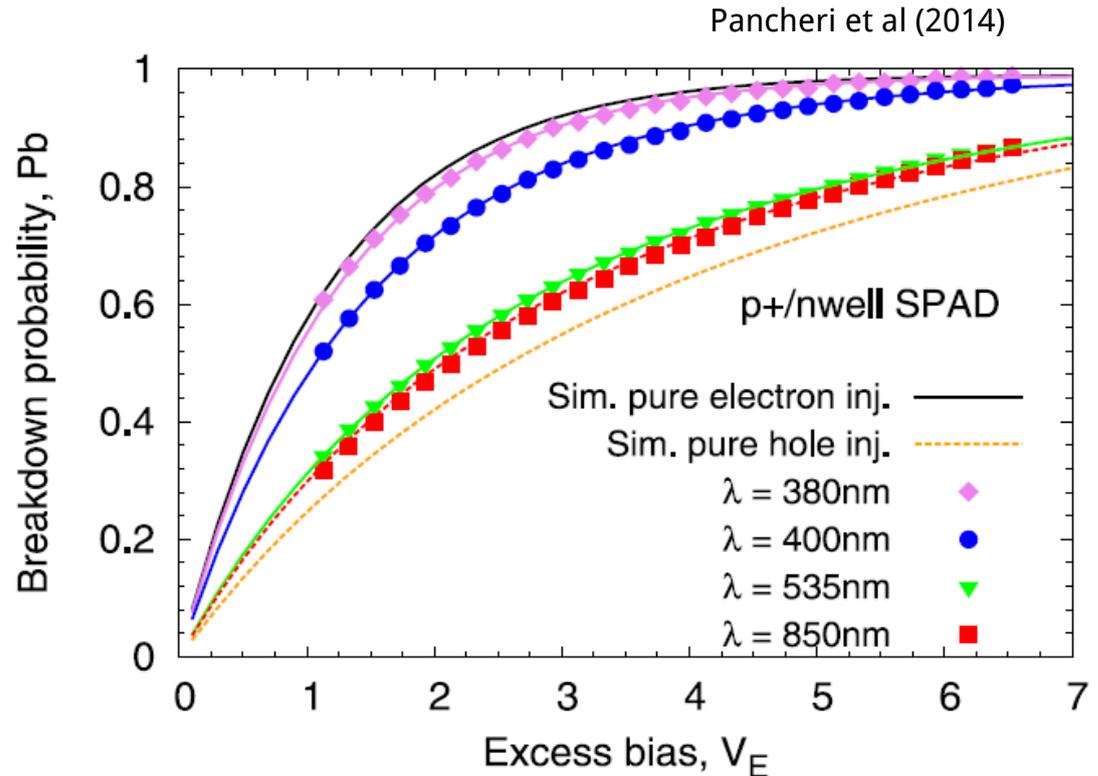
The pragmatic and cost-effective approach to arrive at large sensor sizes

Single SiPMs are typically $< 6 \times 6 \text{ mm}^2$

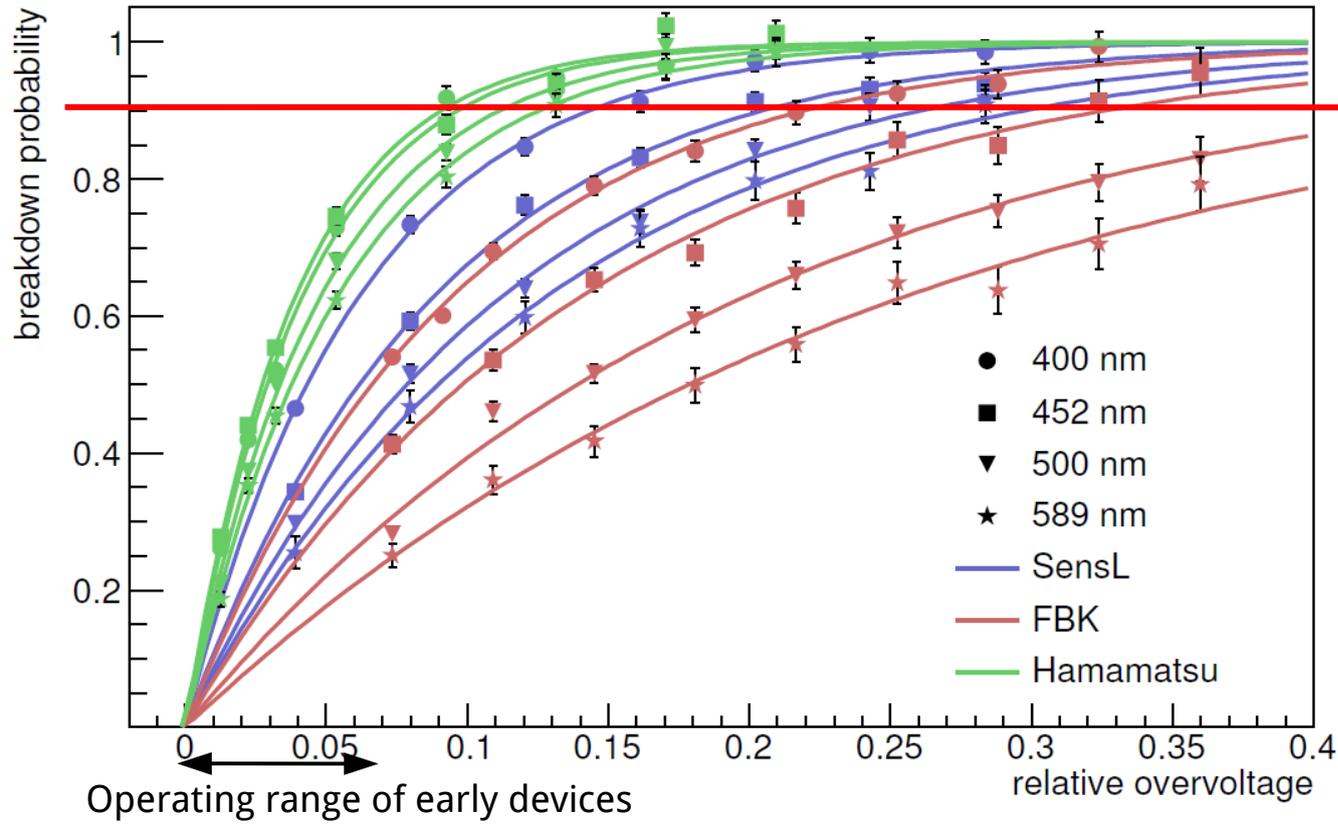
Breakdown Probability vs. Bias



p-on-n structure



Breakdown Probability



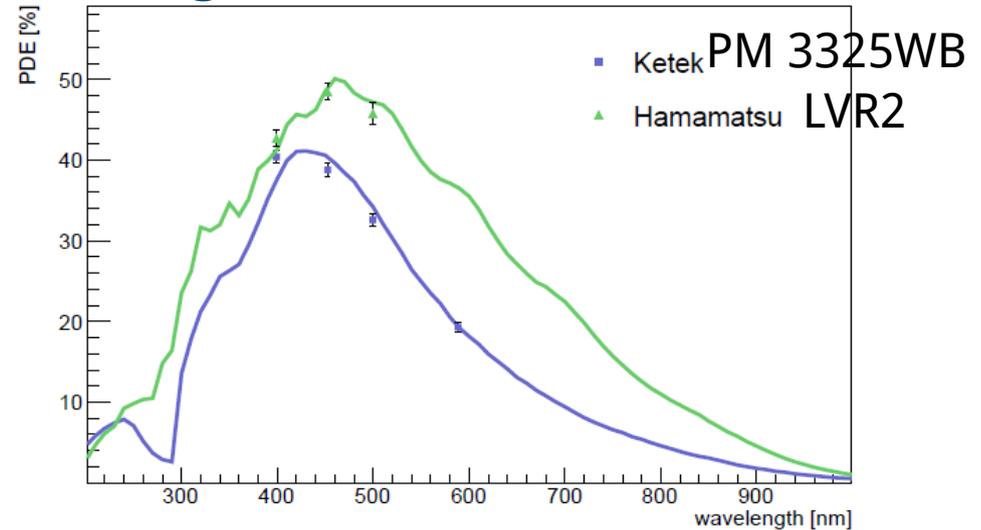
90% breakdown probability

Spectral response is bias dependent

Pathways towards better UV/VUV sensitivity

Spectral response matches emission spectrum of most anorganic & organic scintillators

But below 400 nm ...



For Cherenkov light detection want better NUV sensitivity

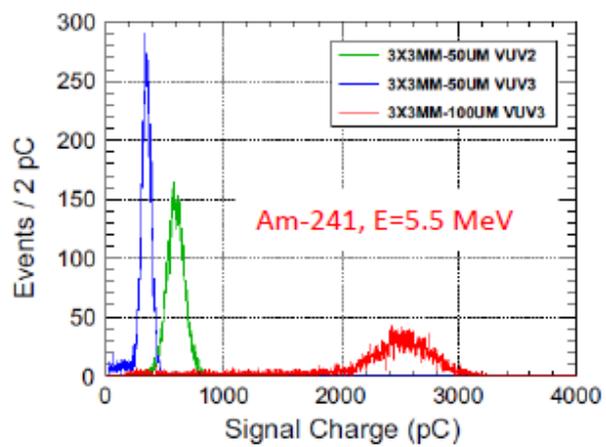
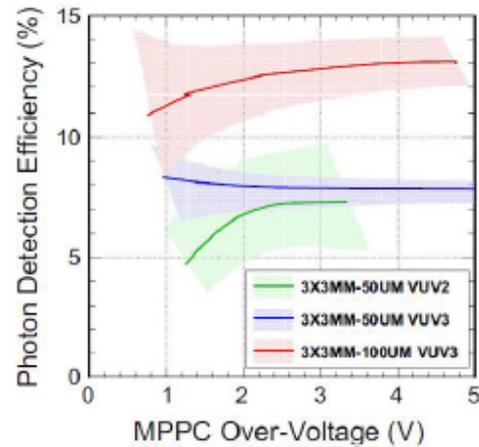
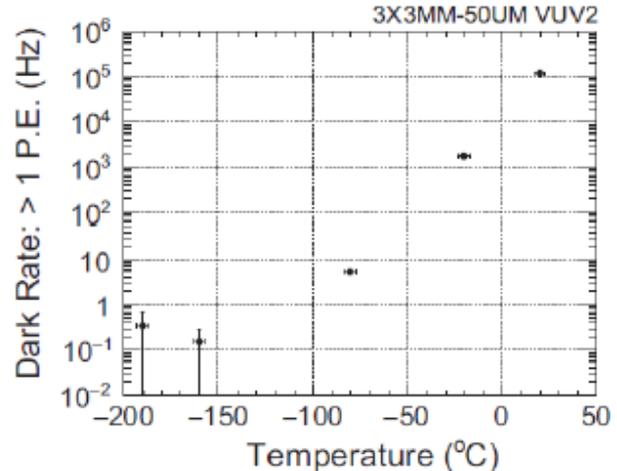
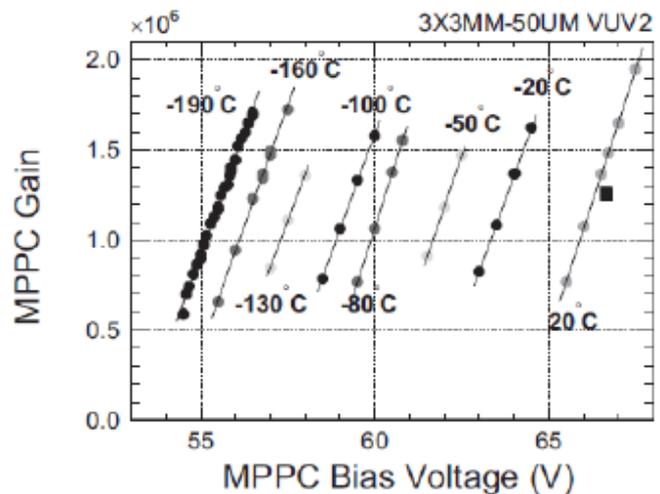
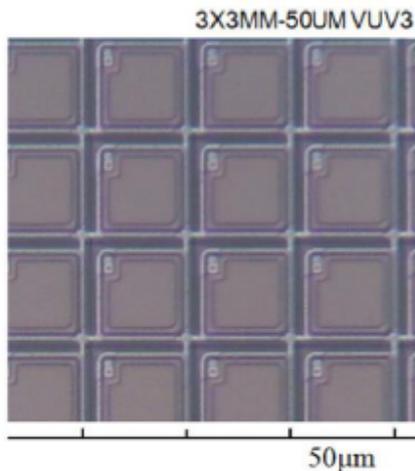
UV transparent coating
thinner passivation layer
anti reflective coating

→ room for improvement 30% - 50%

Otte (2017) to be submitted

Ultimate goal is to have response curves tailored for different applications

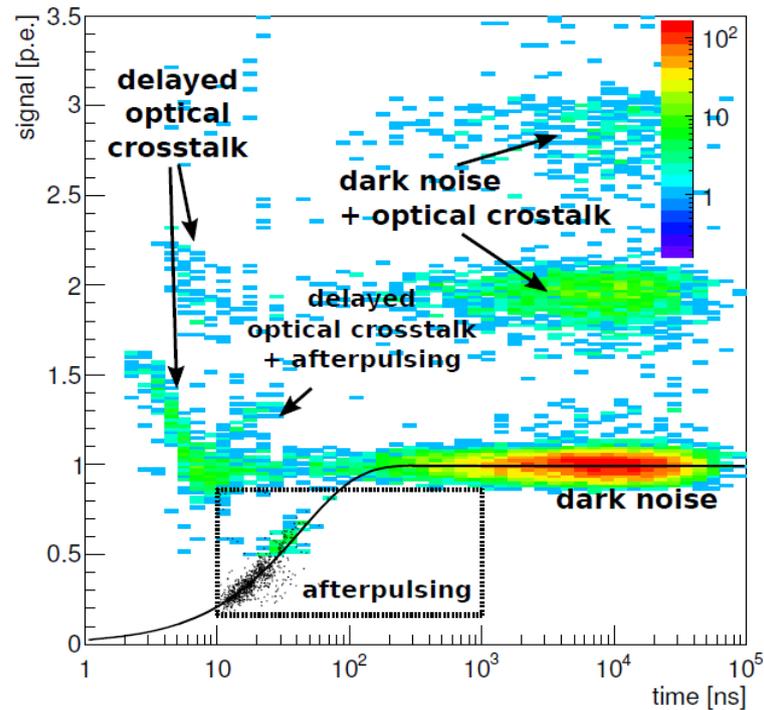
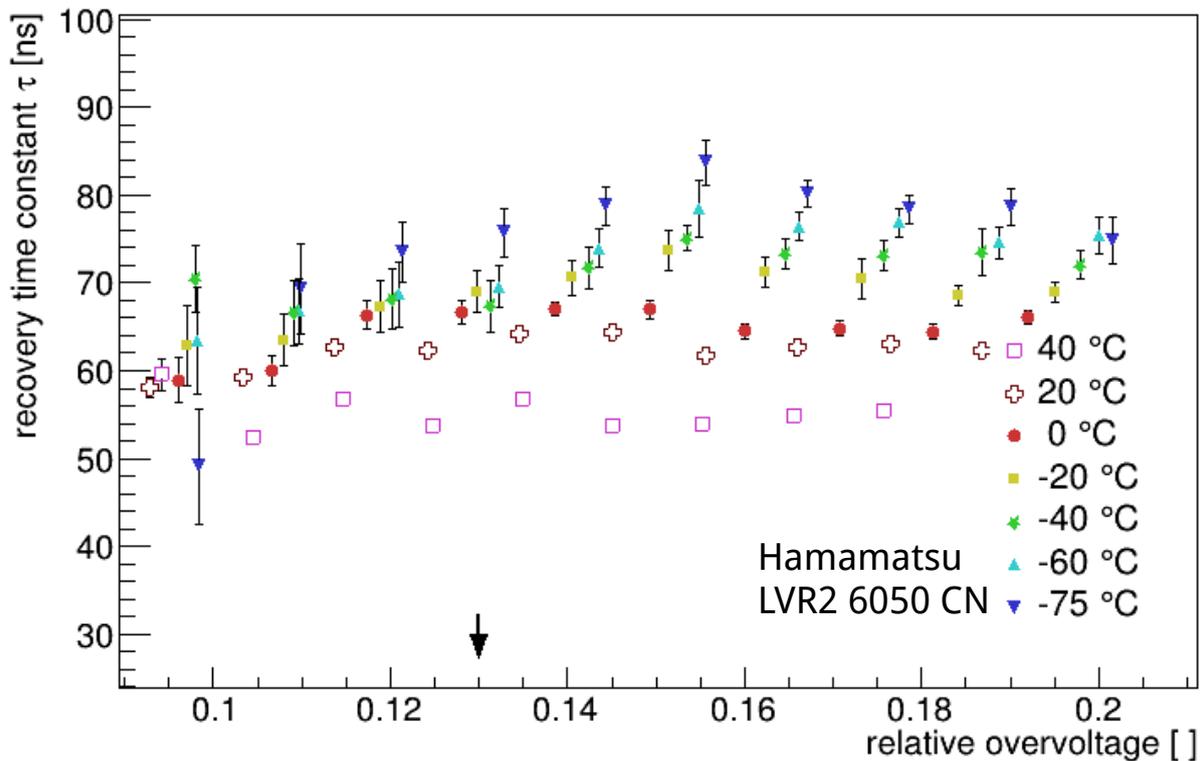
Another important development: SiPMs sensitive to VUV light ($<150\text{ nm}$) were recently developed by HPK for detection LAr ($T=-186\text{ }^\circ\text{C}$) scintillation light ($\lambda = 128\text{ nm}$).

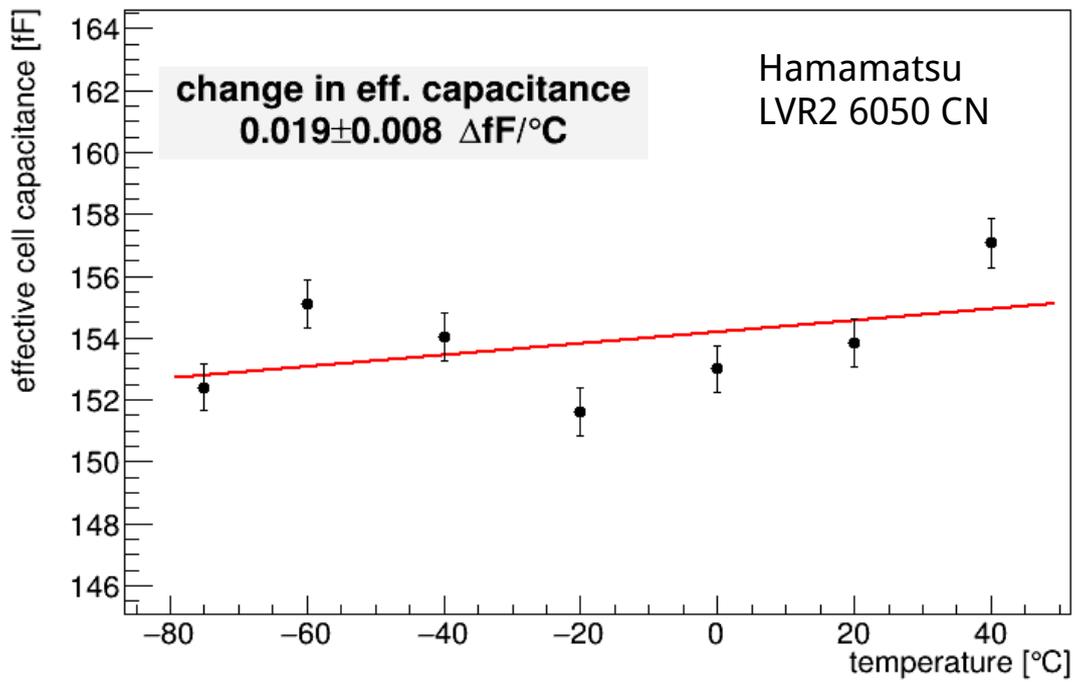
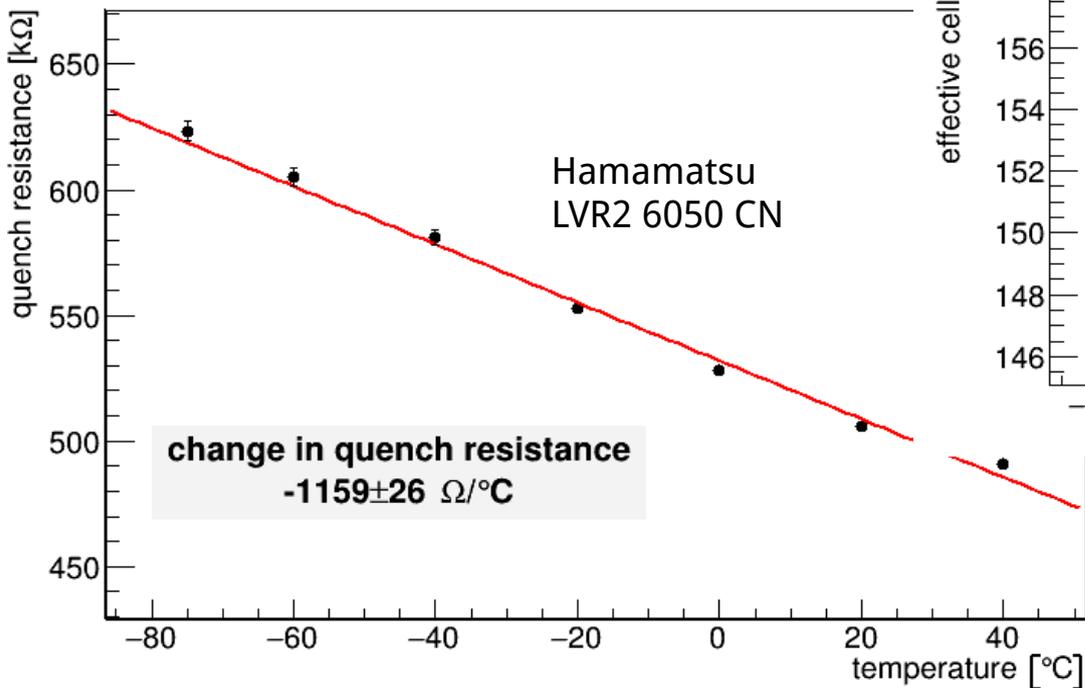


The PDE(128 nm) was measured $\sim 8\%$ for 50 μm pitch SiPMs and $\sim 13\%$ for 100 μm pitch SiPM at $dVB=3\text{ V}$

Cell Recovery Time Constants

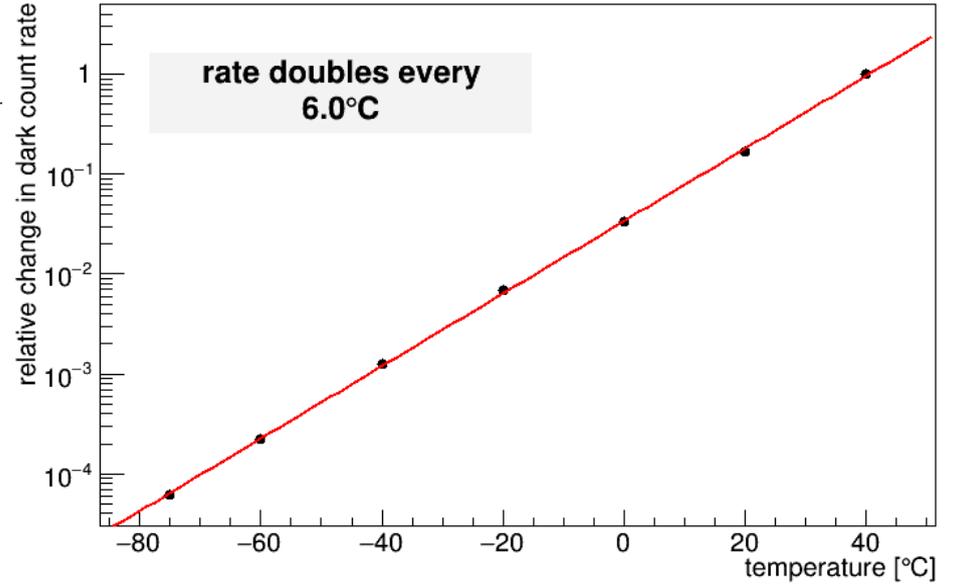
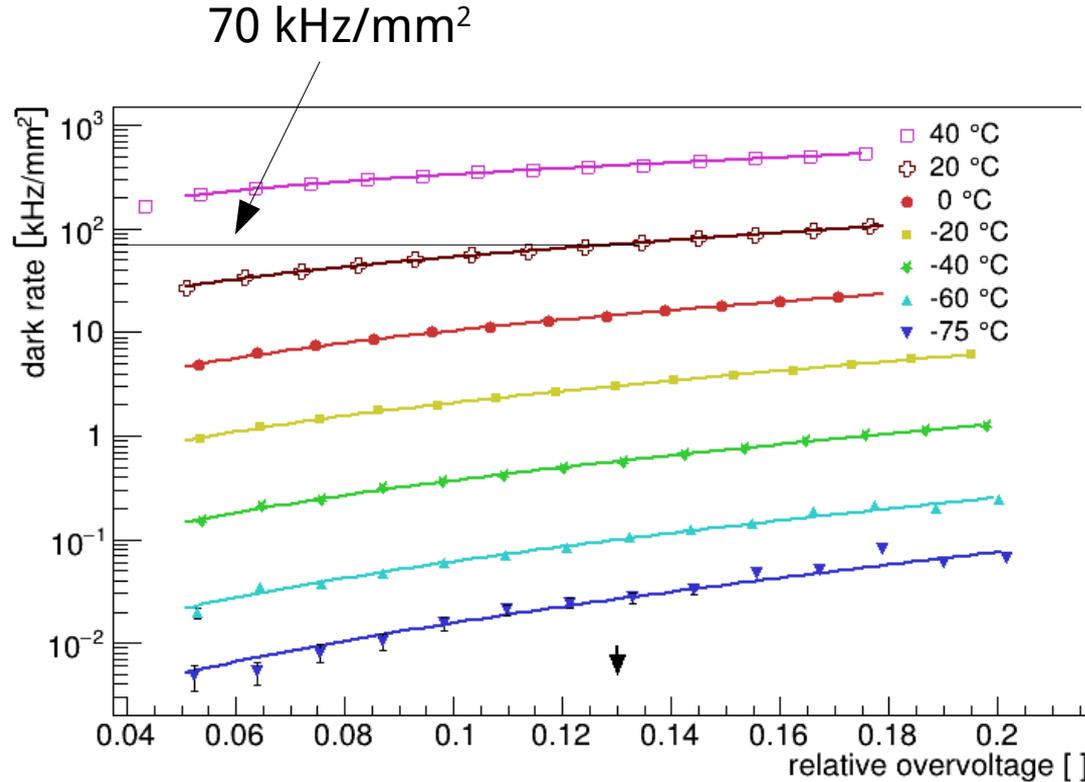
Cell recovery time $\tau = RC$





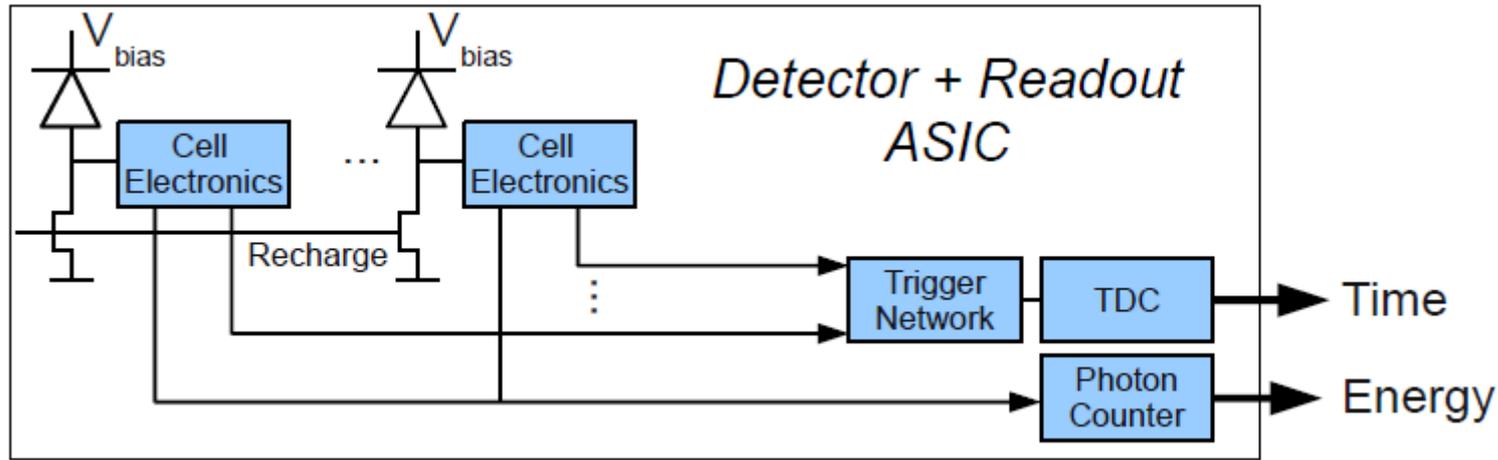
$R \times C_{\text{eff}} \sim \text{recovery time constant}$

Dark Count Rates



Hamamatsu LVR2

SiPM with Active Quenching: dSiPM

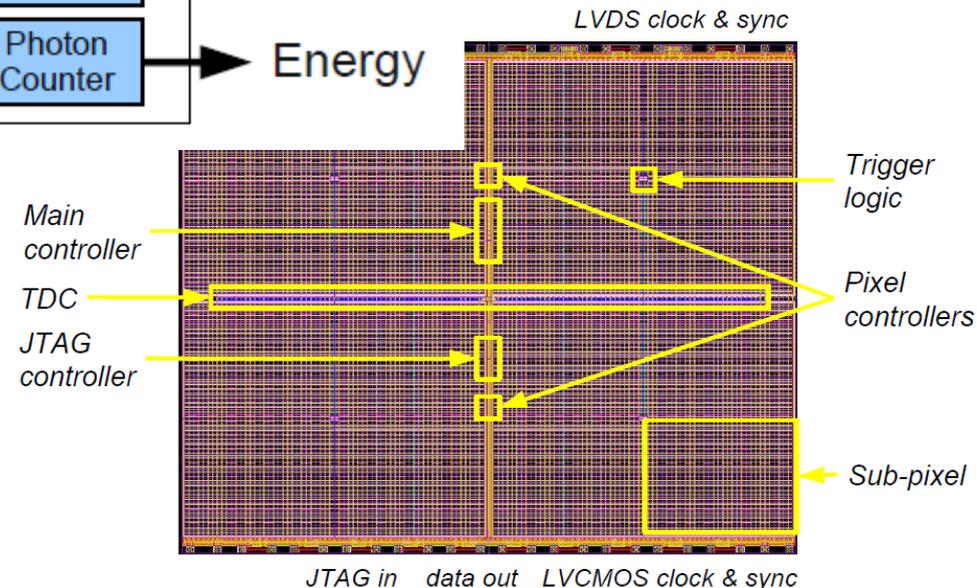


First commercial dSiPM from Philips

Individual pixels can be turned on/off

Excellent timing

Reduced geometrical efficiency → lower PDE
(for now...)



SiPM Advantages and *Nuisances*

- Mechanical robust
- Compact
- Operating voltages < 100V
- Not damaged in bright light
- No aging
- Insensitive to magnetic fields
- Excellent SNR
- Excellent single photon timing (<100 ps)
- Very high photon detection efficiency
- Low radioactivity

What's being worked on

- Radiation hardness
- Better UV/VUV sensitivity
- Lower optical crosstalk
- Lower dark rates
- Size

A near perfect device for many applications

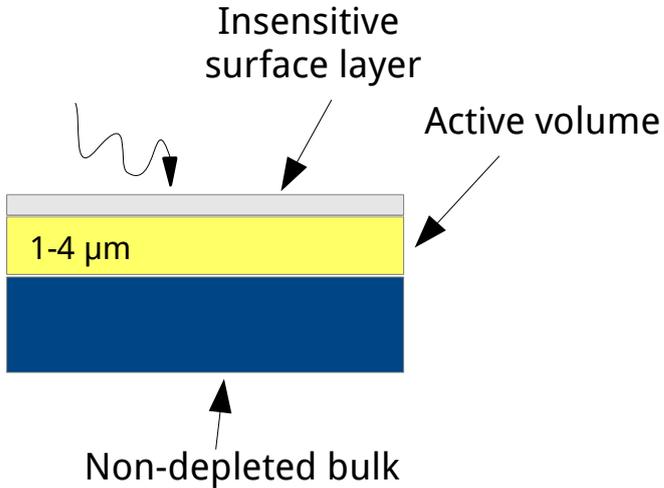
You have Choices



Interactions between producers and users
are very productive!

from W. Ootani

Spectral Response

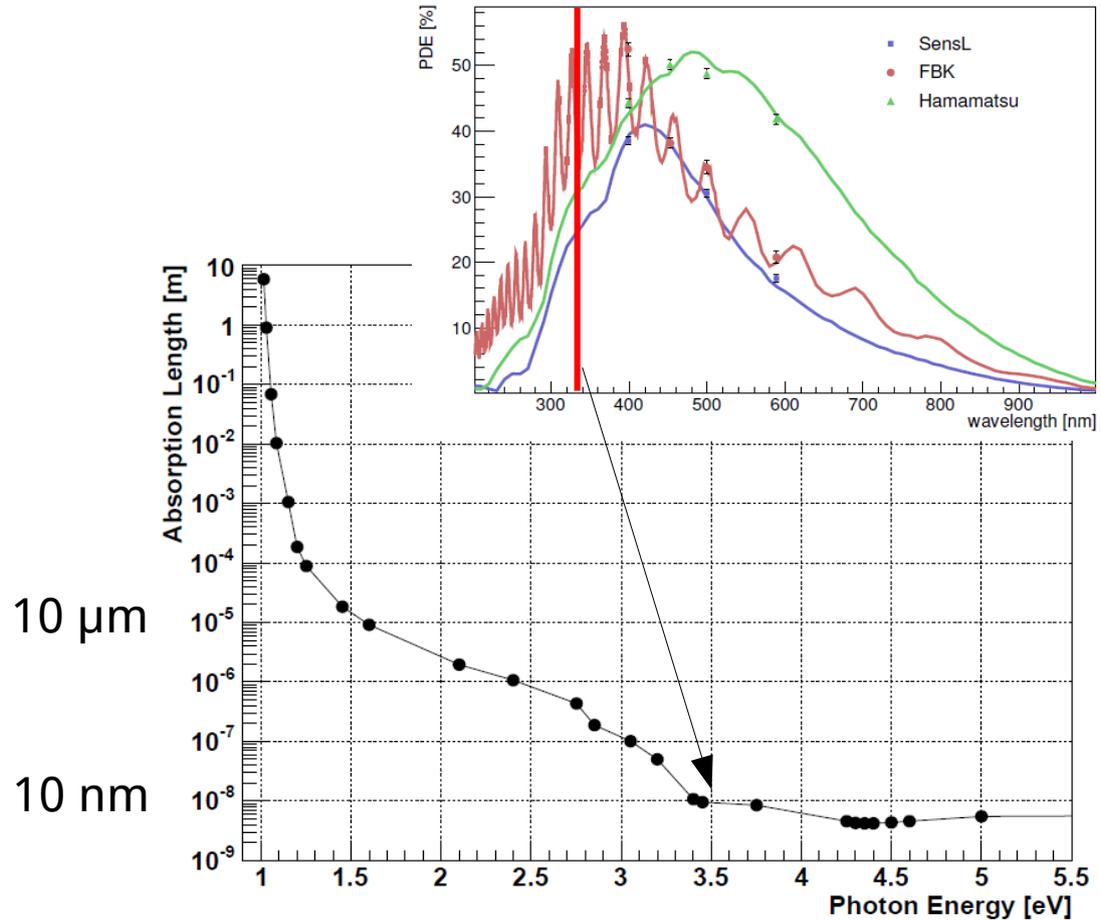


Spectral response determined by:

- photon absorption length
- Surface reflectivity

→ For UV/VUV need:

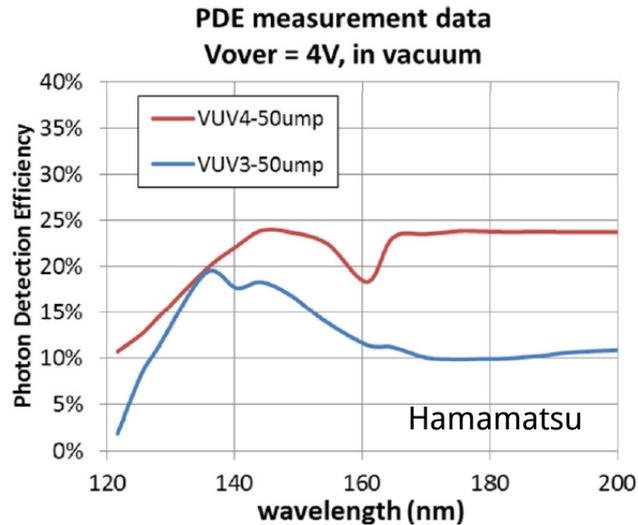
- thin passivation layer
- anti reflective coating
- Wavelength shifter



Response in the VUV

Liquid Nobels are the dominating detection media in HEP/DM in the foreseeable future

→ Need photon detectors that are sensitive between 100 nm and 200 nm



30% PDE seems possible

Efforts will ultimately be limited by silicon properties

See talk by F. Retiere

Solid State Photomultipliers: SiC GaInP, GaAs,...

- Bandgap can be adjusted → spectral response can be tuned
- Potentially better radiation hardness
- Used on industrial scale → infrastructure exists

It is a technological challenge very much like in the early days of SiPMs

